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BARCELONA

11-16 September 2016

LCLS-II KB Mirror Systems: Technical Challenges and Solutions

(Practice of Design Optimization)

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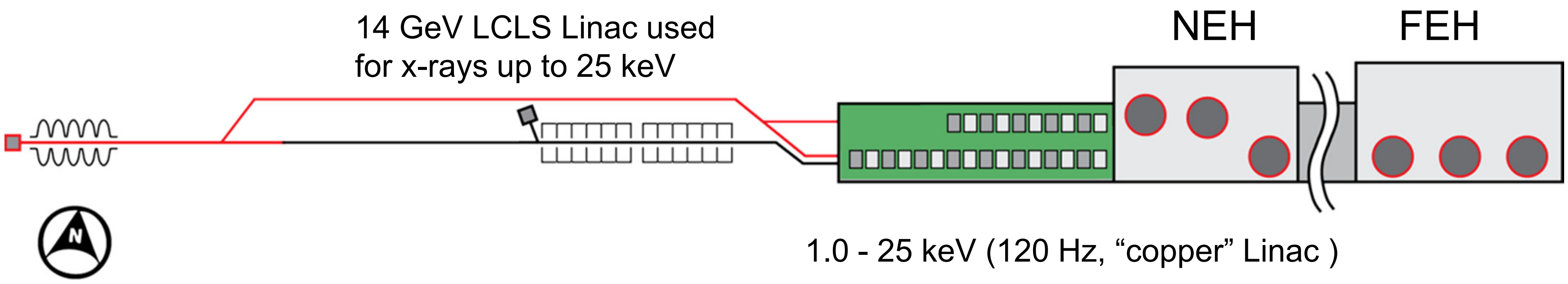
U.S. DEPARTMENT OF ENERGY
Office of Science

SLAC NATIONAL ACCELERATOR LABORATORY

LCLS vs. LCLS-II

LCLS: Linac Coherent Light Source

LCLS vs. LCLS-II

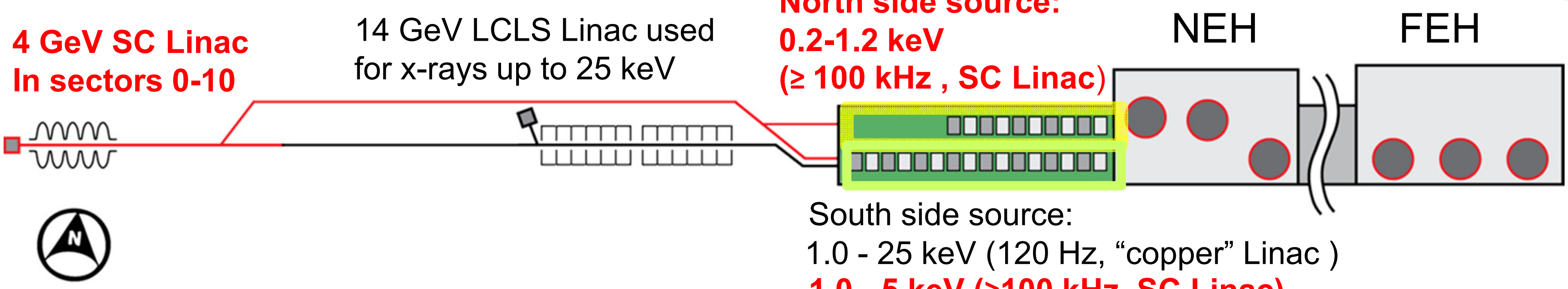


LCLS vs. LCLS-II

4 GeV SC Linac
In sectors 0-10

14 GeV LCLS Linac used for x-rays up to 25 keV

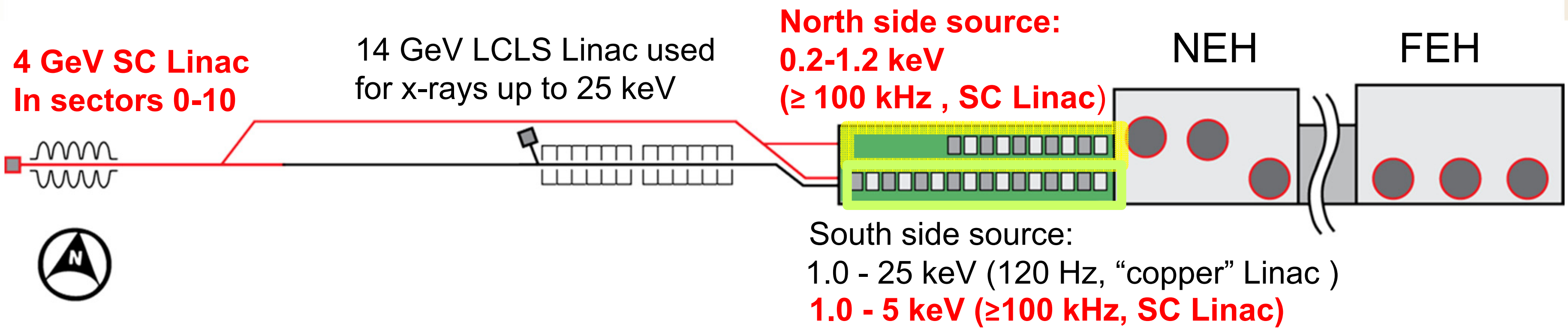
North side source:
0.2-1.2 keV
(≥ 100 kHz , SC Linac)



South side source:
1.0 - 25 keV (120 Hz, "copper" Linac)
1.0 - 5 keV (≥100 kHz, SC Linac)

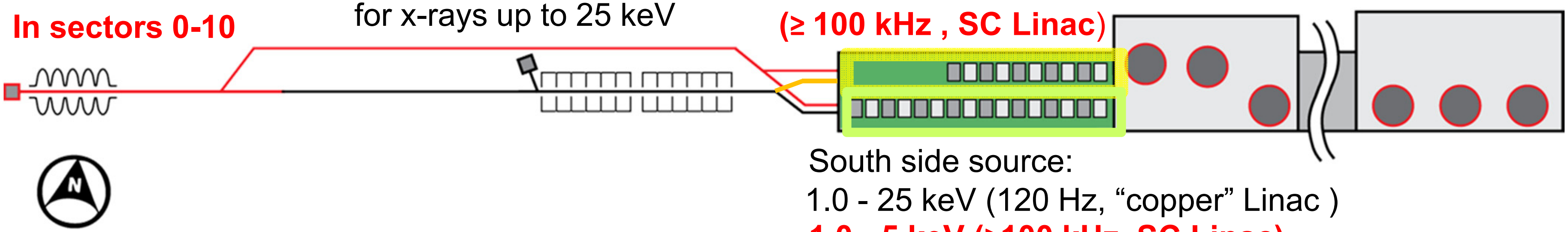
LCLS vs. LCLS-II

SLAC



	LCLS-I Baseline	Now	HXU - Cu	HXU - SC	SXU - SC	SXU – Cu (TBC)
Photon Energy Range (eV)	800 - 8,000	250 - 12,800	400 - 25,000	**1000 - 5000**	**200 - 1300**	250 - 6000
Repetition Rate (Hz)	120	120	120	**929,000**	**929,000**	120
Per Pulse Energy (mJ)	~ 2	~ 4	~ 4	**~ 0.2**	**~ 2**	~ 8
Maximum average power (W)	0.24	0.48	0.48	**200**	**600**	0.96
Photons/Second	~ 10^{14}	~ 10^{14}	~ 10^{14}	**~ 10^{16}**	**~ 10^{17}**	~ 10^{14}

LCLS vs. LCLS-II



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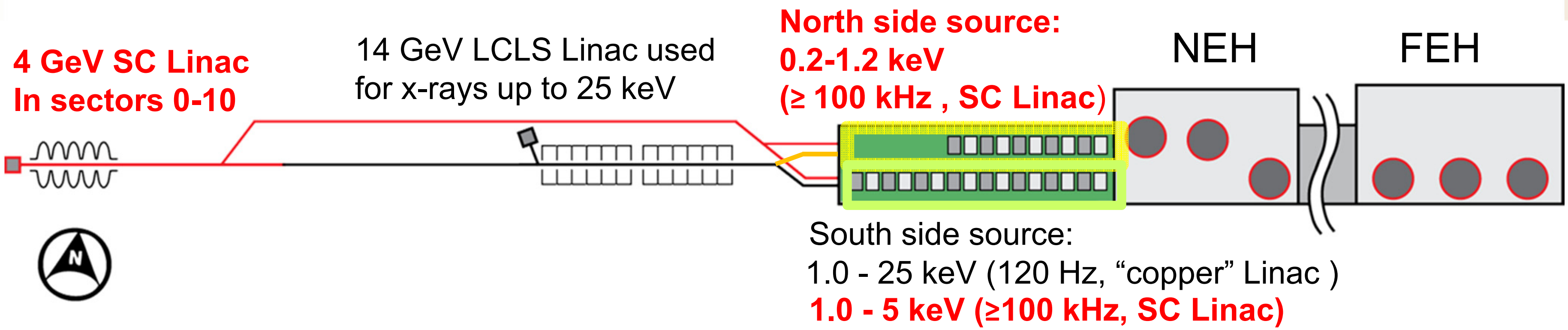

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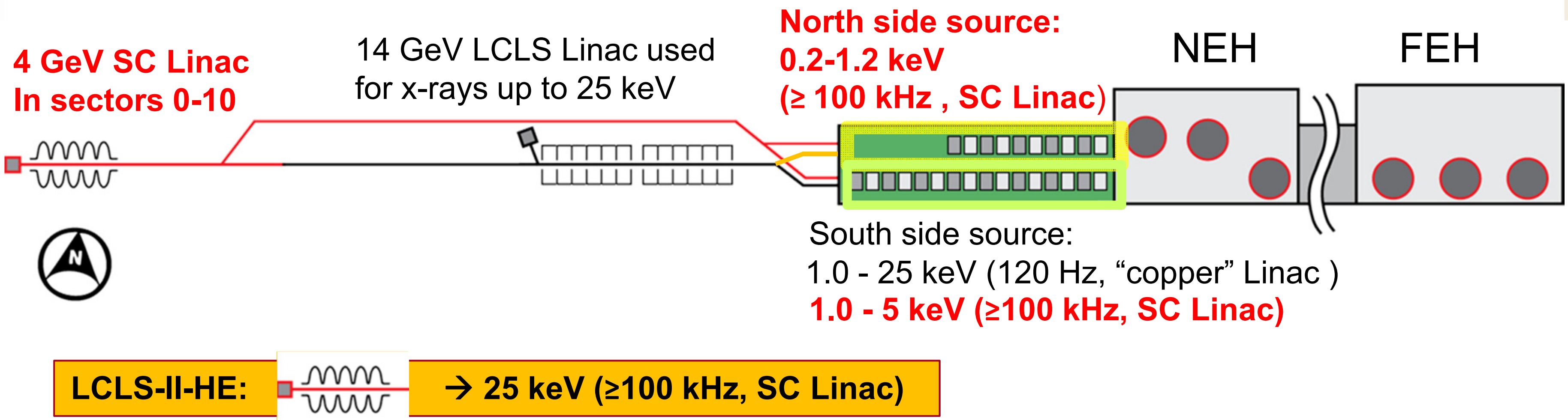

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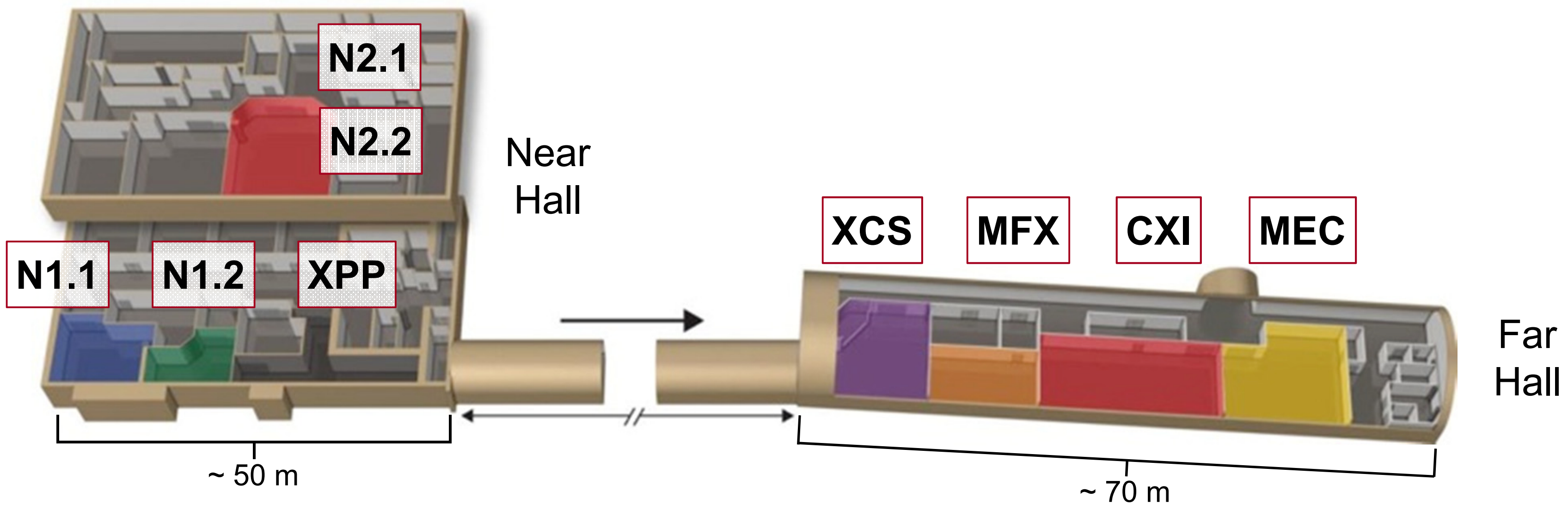
X-ray instrument plans for LCLS-II

- **7 instruments fed by a single undulator at present**
- **9 instruments available for LCLS-II**



SXU → NEH 1.1, NEH 2.1, NEH 2.2, NEH 1.2
HXU → NEH 1.2, XPP, XCS, MFX, CXI, MEC

NEH 1.1: Atomic, Molecular and Optical
NEH 2.1: Resonant Inelastic X-ray Scattering
NEH 2.2: Soft X-ray Research
} 3 Soft X-ray

NEH 1.2: Tender X-ray Instrument
} 1 "tender" x-ray

XPP: X-ray Pump Probe
XCS: X-ray Correlation Spectroscopy
MFX: Macromolecular Femtosecond Crystallography
CXI: Coherent X-ray Imaging
MEC: Matter in Extreme Conditions
} 5 Hard X-ray

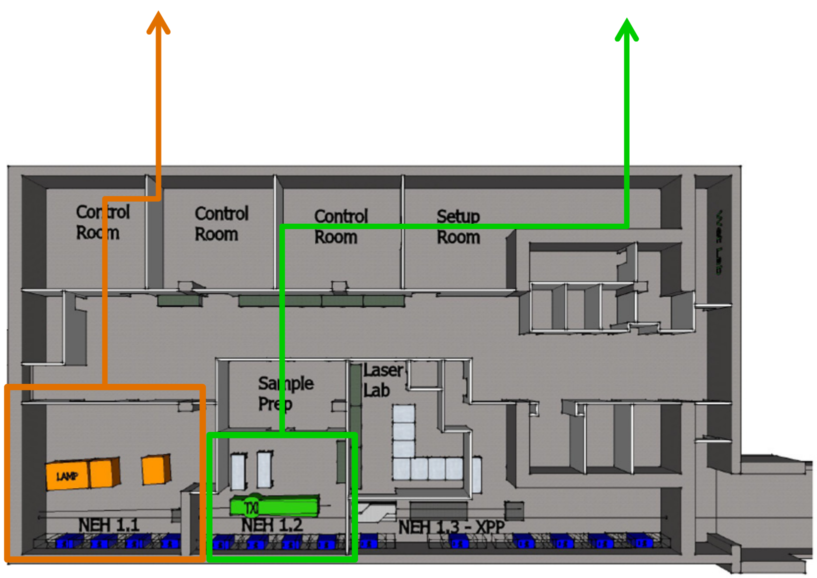
KB mirror systems for Soft and Tender X-ray

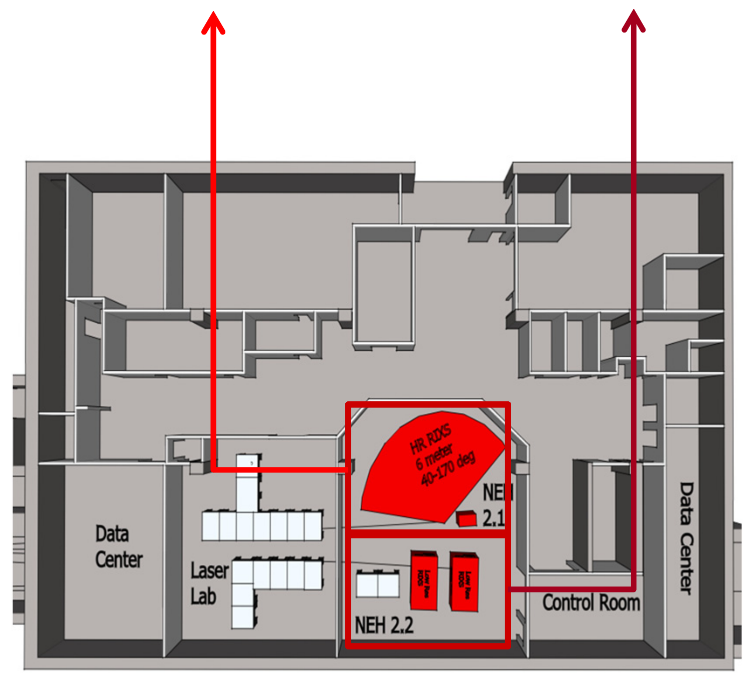
NEH 1.1
- High Flux Soft X-ray
- **Bendable K-B Pair**
  - 1 µm
- **Fixed Figure K-B Pair**
  - 300nm
- 250-1300 eV

NEH 1.2
- Tender X-ray Instrument
- **SXR Bendable K-B Pair**
  - 1 µm
- **HXR Bendable K-B Pair**
  - 1 µm
- 400-6000 eV

NEH 2.1
- RIXS
- **Bendable K-B Pair**
  - 2x10µm
- 250-1350 eV

NEH 2.2
- Mono Soft X-Ray
- **Bendable K-B Pair**
  - 1x4 µm
- 250-1350 eV





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SLAC

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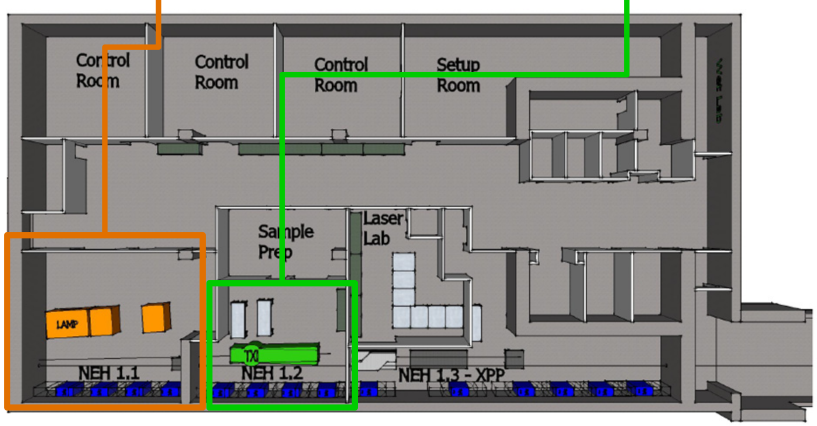

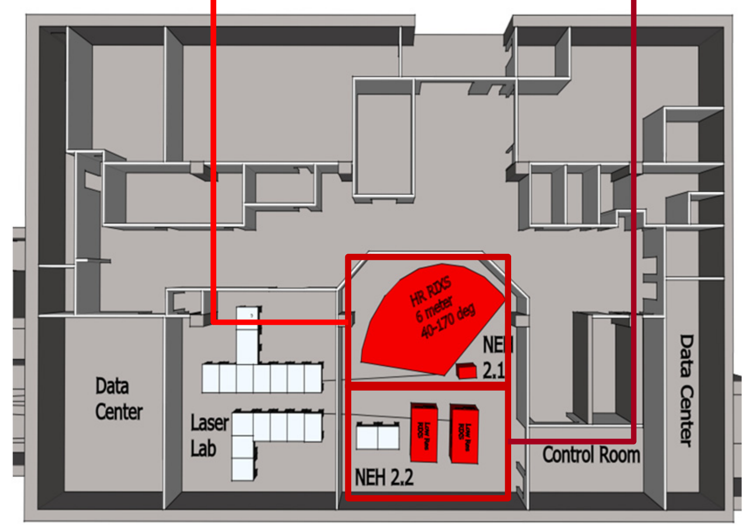

→ 6 pairs of KB mirror systems

Some properties of XFEL, optics requirements

SLAC

- **Nearly monochromatic beam (especially with self-seeding)**
  - K-B mirrors absorbs ~ 10% XFEL beam power, → to be actively **cooled**

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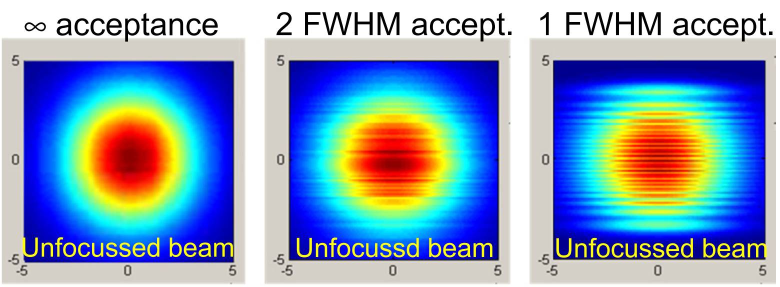
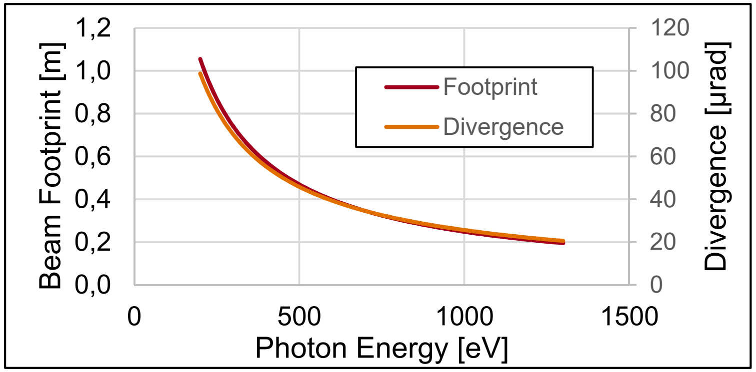
- **Fully coherent photon beam → Wavefront preservation**
  - **2*FWHM beam size needed**



θ=14 mrad



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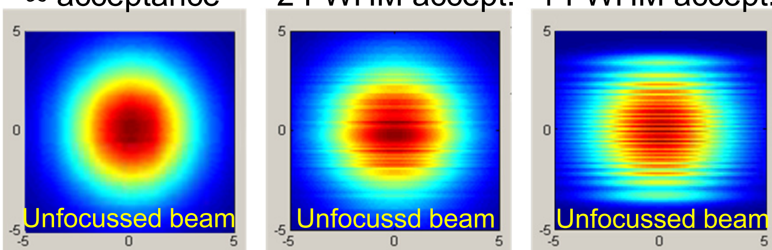
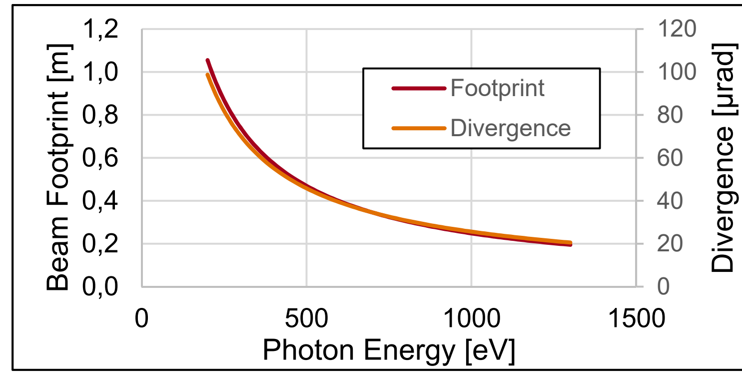
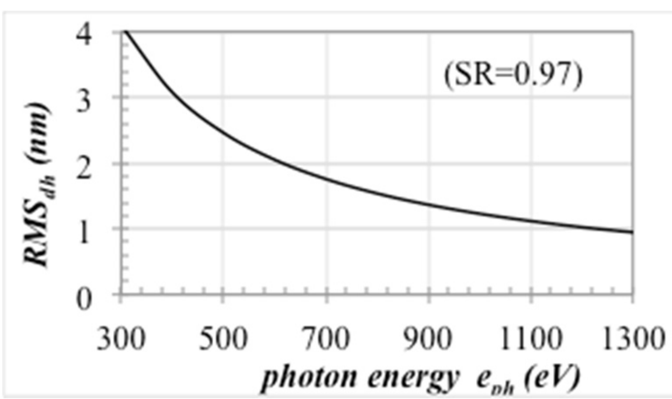
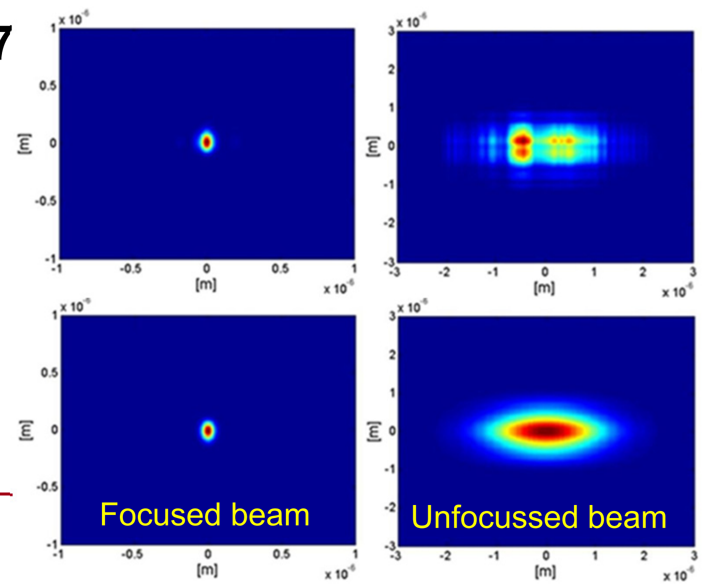


θ=14 mrad



  - **Shape error requirement (SR ≥ 0.97**



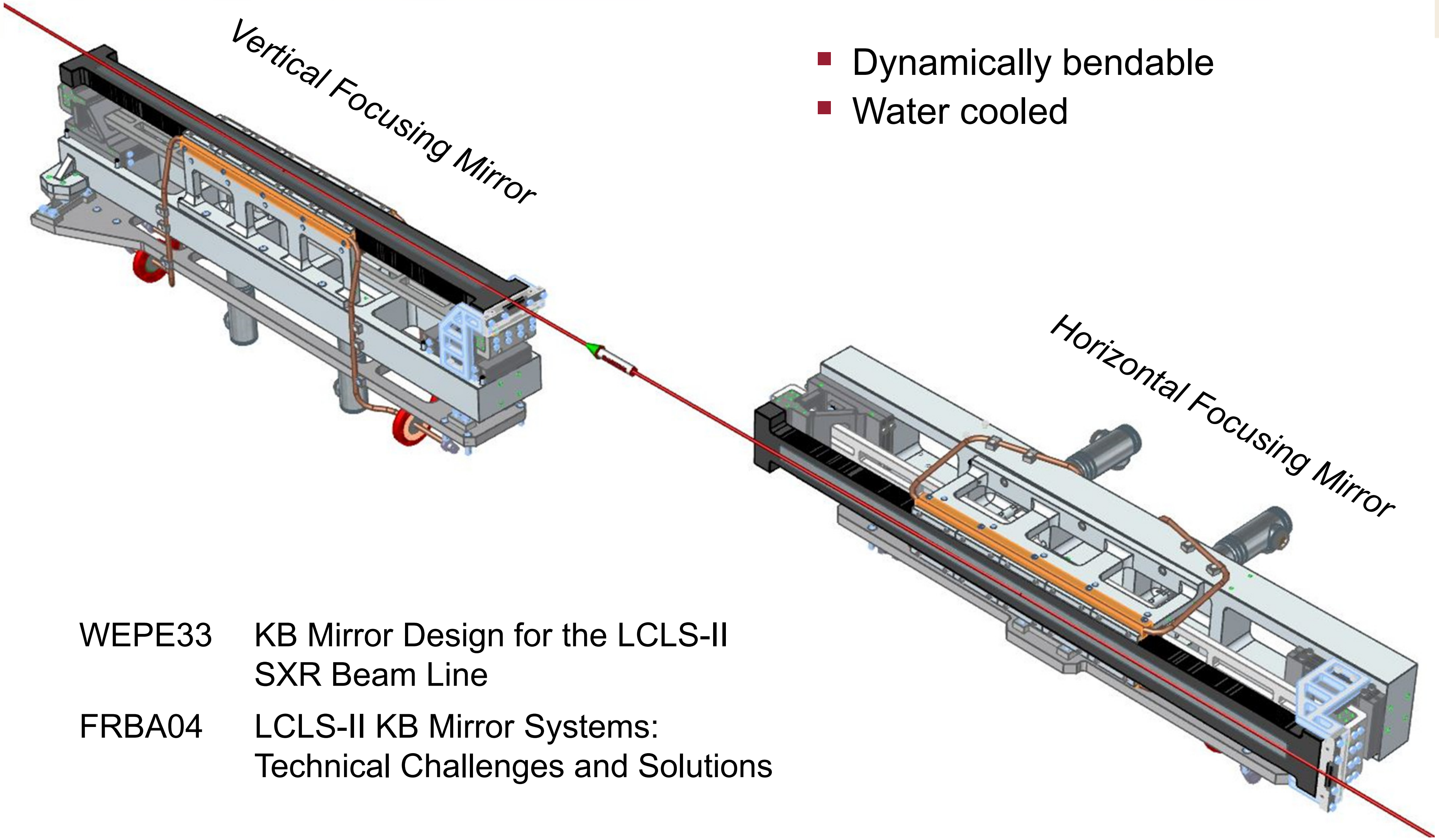


SR=0.80

SR=0.97

LCLS-II K-B mirror system

- Dynamically bendable
- Water cooled

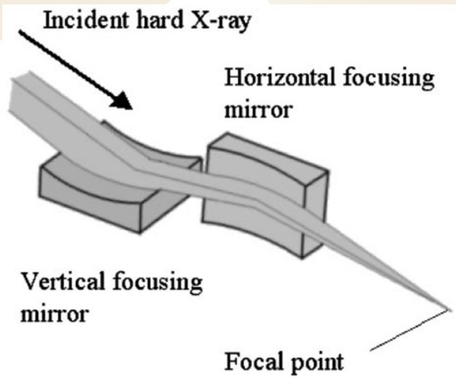


WEPE33 KB Mirror Design for the LCLS-II SXR Beam Line

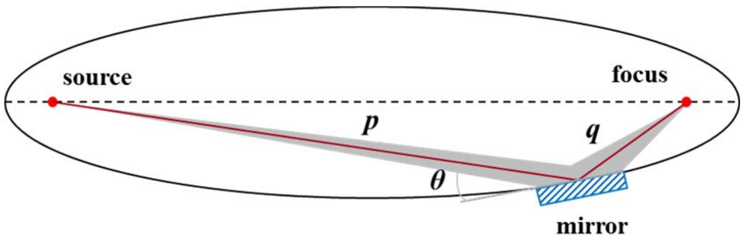
FRBA04 LCLS-II KB Mirror Systems: Technical Challenges and Solutions

KB mirror system, technical challenges

- **Kirkpatrick-Baez (K-B) mirror configuration**



- **Ellipsoidal shape**



- **Technical challenges**
  - Large Acceptance → Long mirror
  - Variable Source & Focal Points → Bendable Mirror
  - **Sub Nanometer Shape Error** → Limited Suppliers
  - High Demagnification → Tight Bending (stress issues,…)
  - Few tenth nrad residual bending error → **Variable Mirror Width**
  - High Thermal Loads & Variable Footprint → **Innovated Cooling**
  - **Minimize the coupling between the mirror Bending & Cooling**

Technical challenges

SLAC

- Large Acceptance → Long mirror
- Variable Source & Focal Points → Bendable Mirror
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- High Demagnification → Tight Bending (stress issues,…)
- **Sub-μrad residual bending error → Variable Mirror Width**
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Mirror profile optimization

➤ **Width profile defined by Bending Equation (BE)**

$$w(x) = \frac{12M(x)}{Et^3} R(x)$$

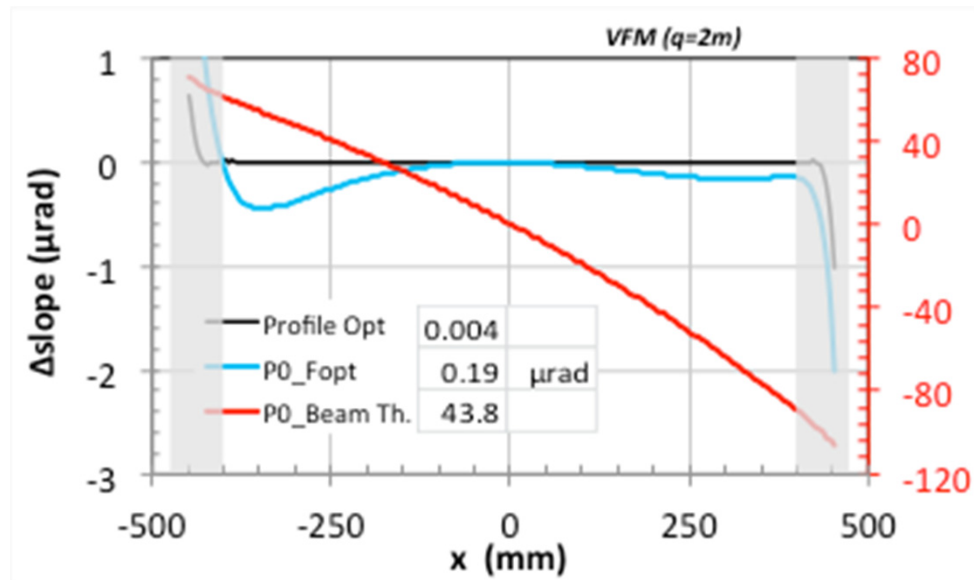
$$z(x) = \frac{\sin\theta(p+q)}{4pq + (p-q)^2 \cos^2\theta} \times \{2pq - 2[(pq)^2 - pqx^2 - xpq(p-q)\cos\theta]^{1/2} - x\cos\theta(p-q)\}$$

Residual Slope Error (RSE) :

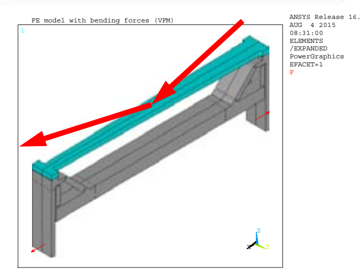
Δslope = *slope* – *slope*$_{ellipse}$

$F_1 = F_2 = 60$ N

$F_1 = 62.92$ N
$F_2 = 63.58$ N

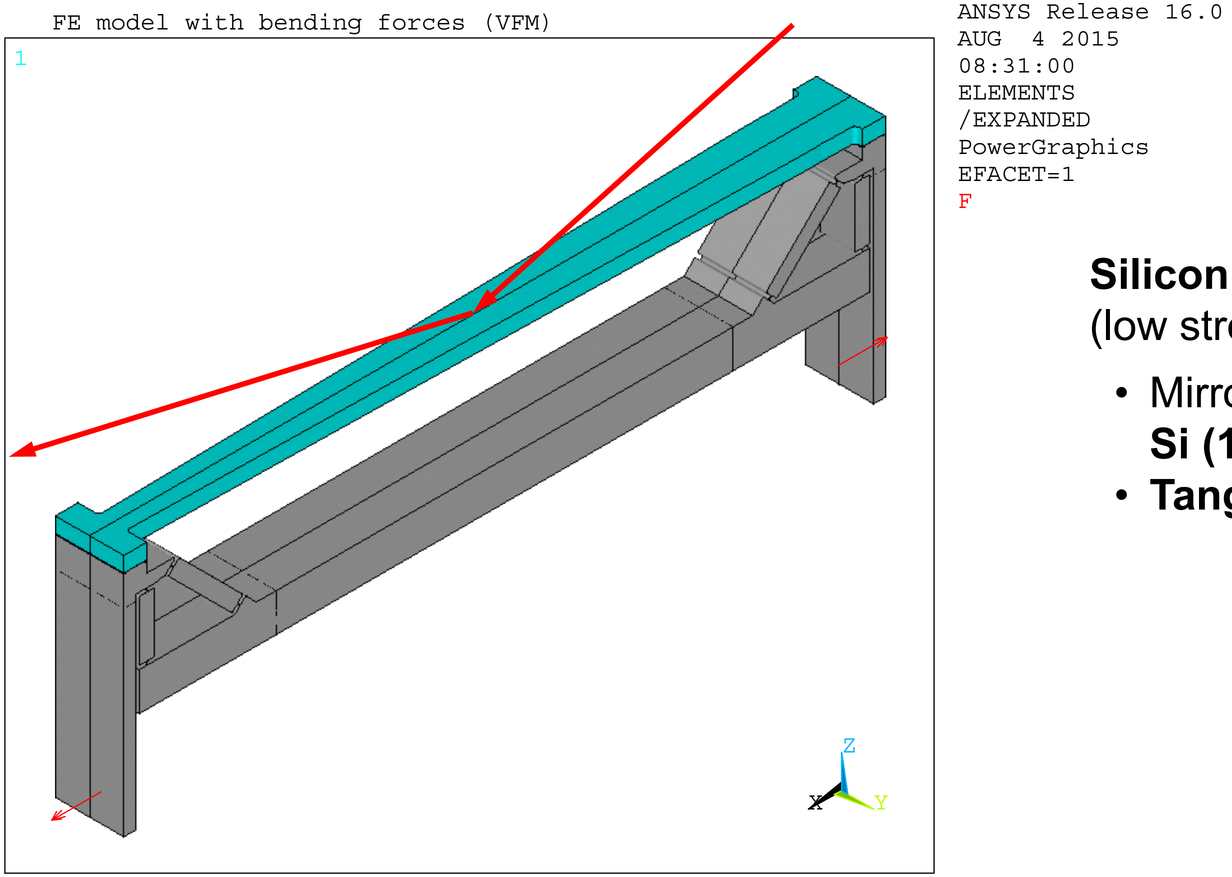


➤ **Limitation of the analytical formula (Beam theory approximation)**



Mirror profile optimization

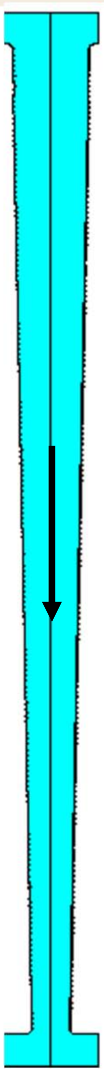
FE model with bending forces (VFM)



LCLS-II KB mirror: VFM, Fin=60, Fout=60 N, Ndxc=8, i=5

Silicon crystal orientation
(low stress & bending force)

- Mirror optical surface // **Si (110)** plan
- **Tangential-axis // [001]**

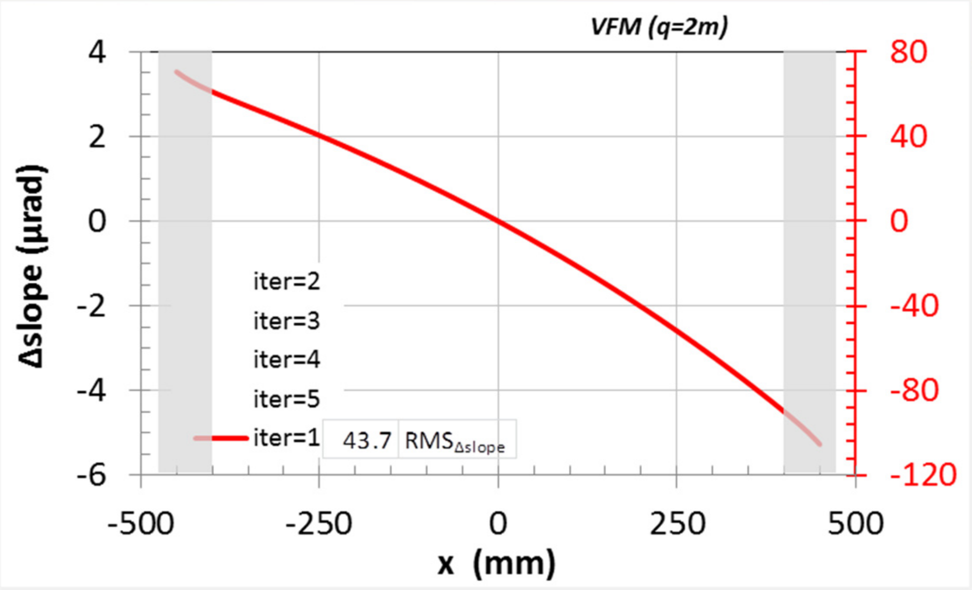


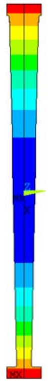
- *L. Zhang, **SMEXOS** (2009), Grenoble, France*
- *L. Zhang et al., **AIP Conference Proceedings** 1234, 801 (2010); doi: 10.1063/1.3463335*

Optimized Mirror Profile (VFM, q=2m)

V_{201505}

Optimized Mirror Profile – bending performance



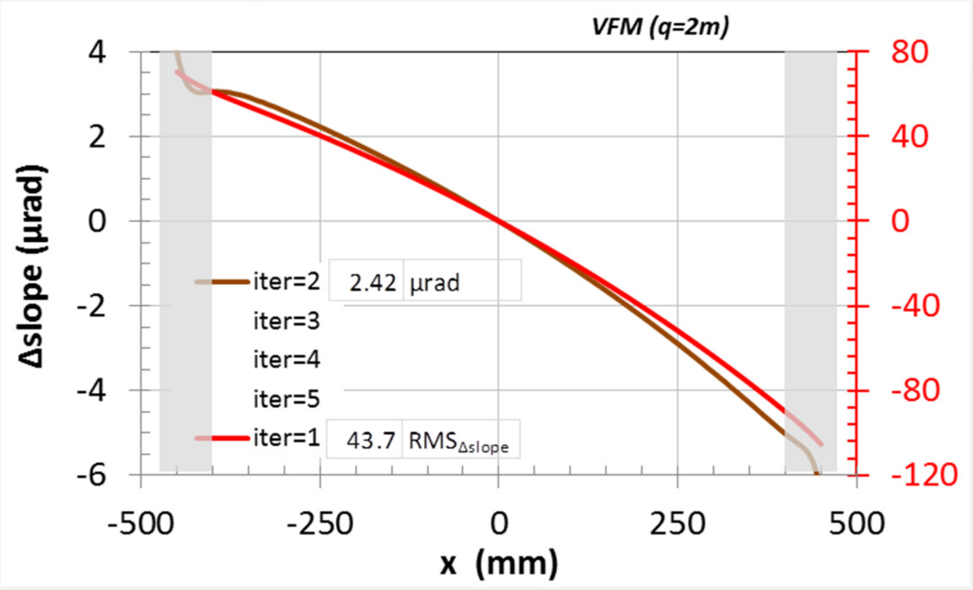


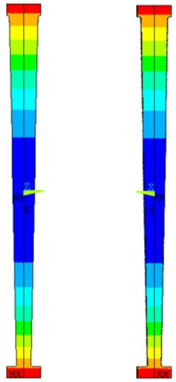
iter=1

→ **Following effects to be taken into account**

- Bender stiffness (not negligible)
- Anticlastic-bending effects
- Anisotropy of the Si crystal
- Geometrical non-linear effects in the simulation

Optimized Mirror Profile – bending performance





iter=1 iter=2

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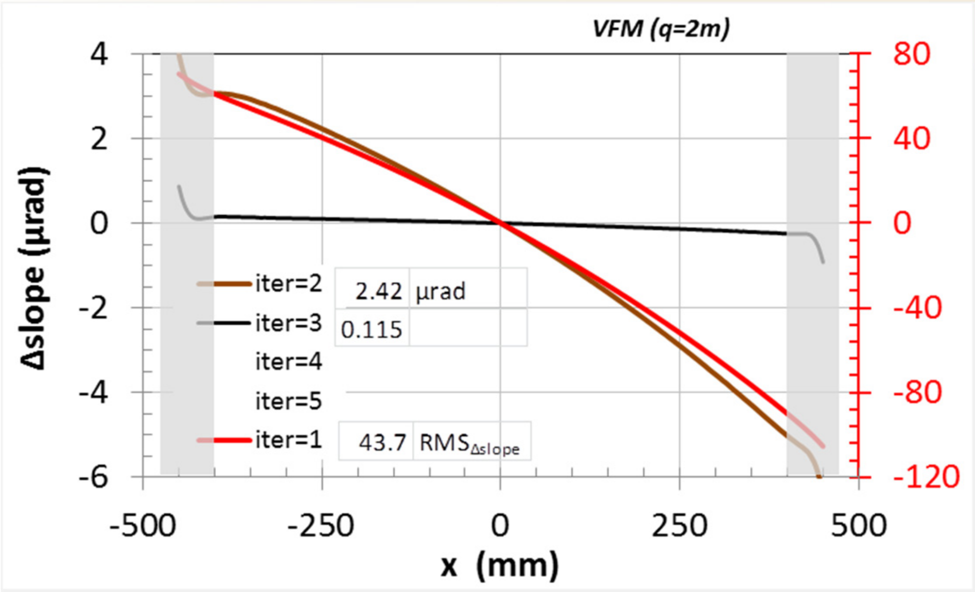
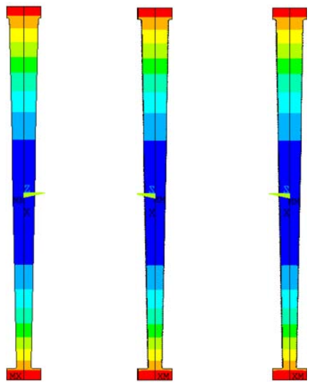
Optimized Mirror Profile – bending performance





iter=1 iter=2 iter=3

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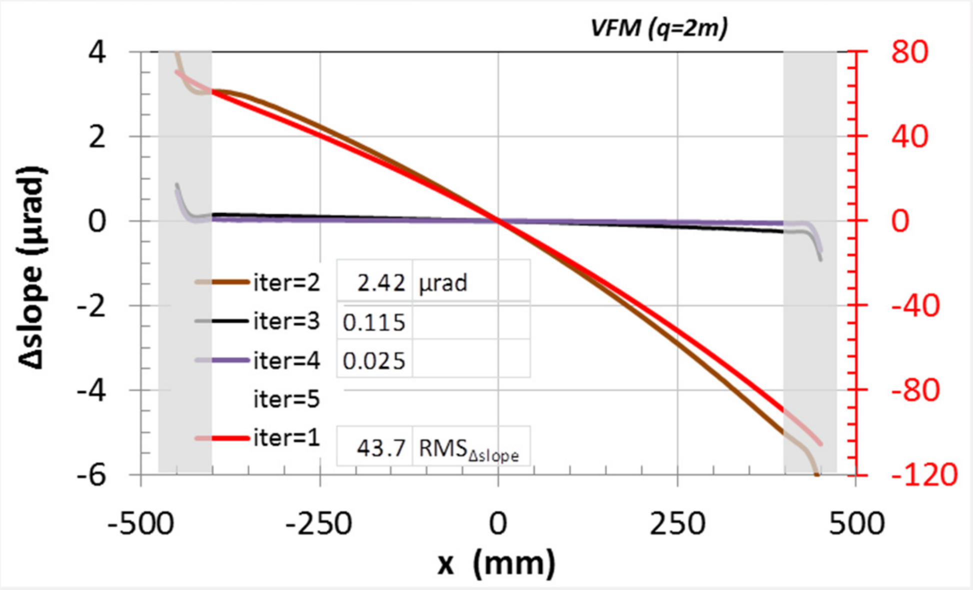
Optimized Mirror Profile – bending performance

SLAC



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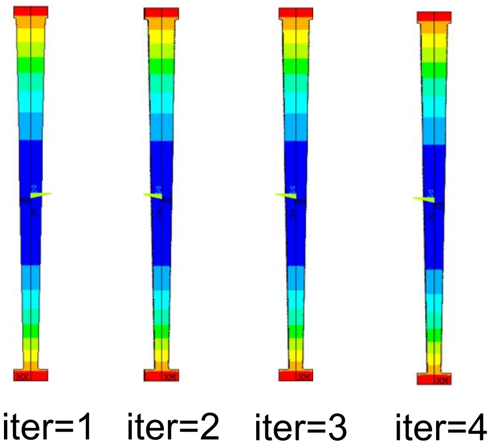

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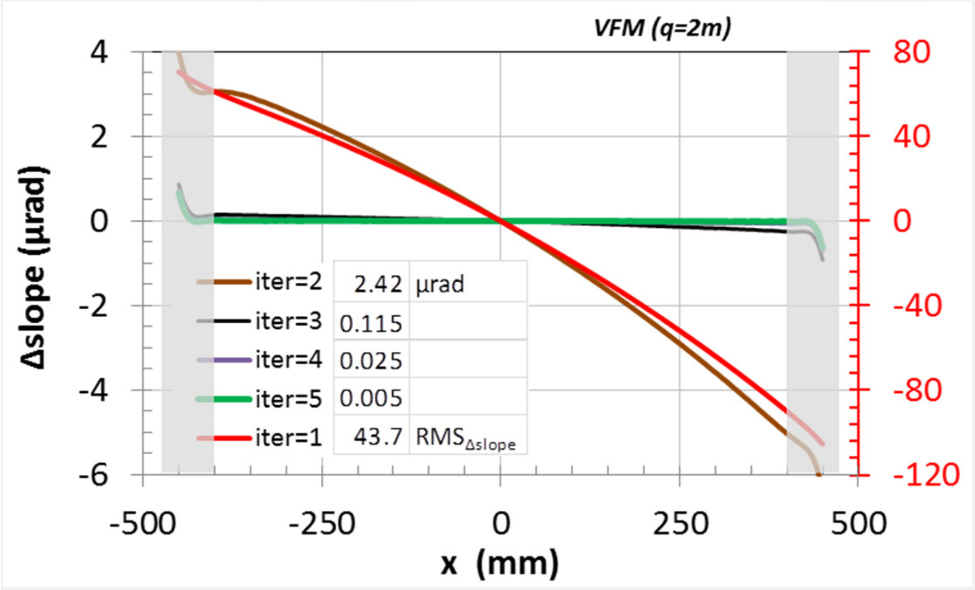

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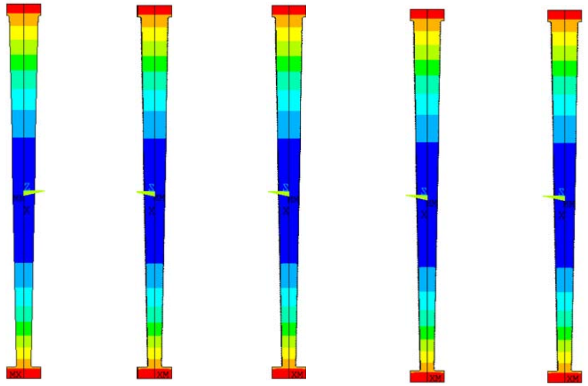

iter=1 iter=2 iter=3 iter=4 iter=5

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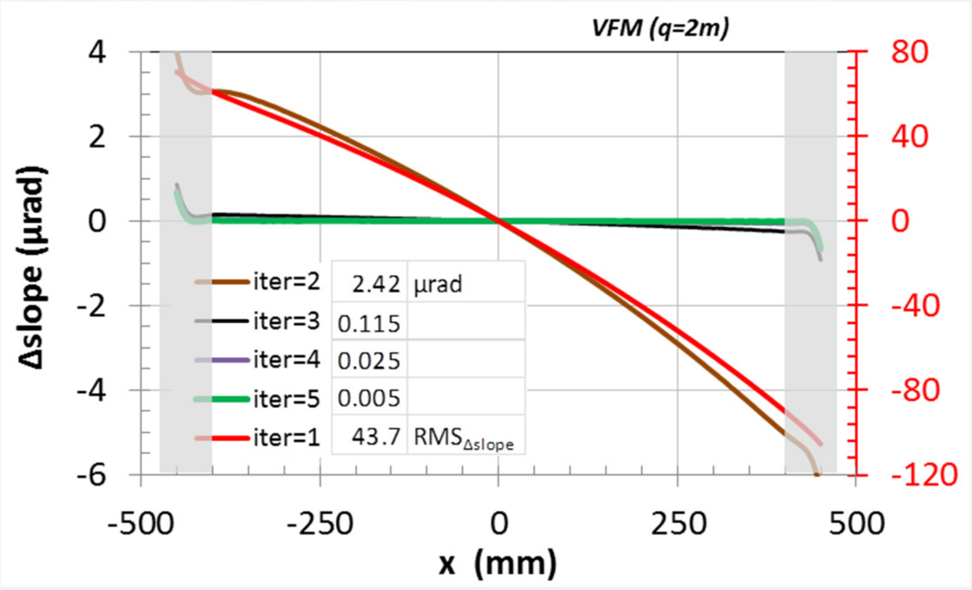

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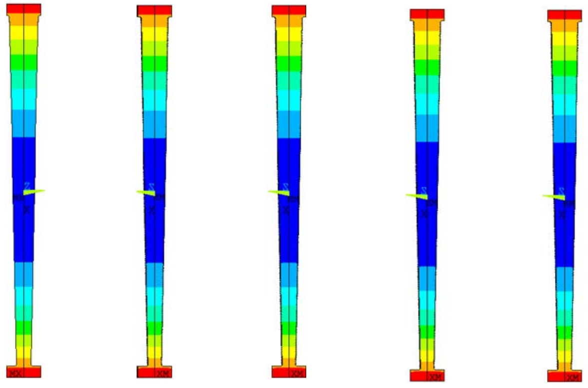

RMS$_{\Delta slope}$ (reduction factor : **~ 10^4**)

- **43.7 µrad** (with the profile defined by BE)
- **0.005 µrad** (with the optimized profile by FEA)

RMS$_{\Delta slope\text{-}opt}$ /*slope*$_{PV\text{-}ellipse}$ ~ **2 10^{-6}**

Technical challenges

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- High Demagnification → Tight Bending (stress issues,…)
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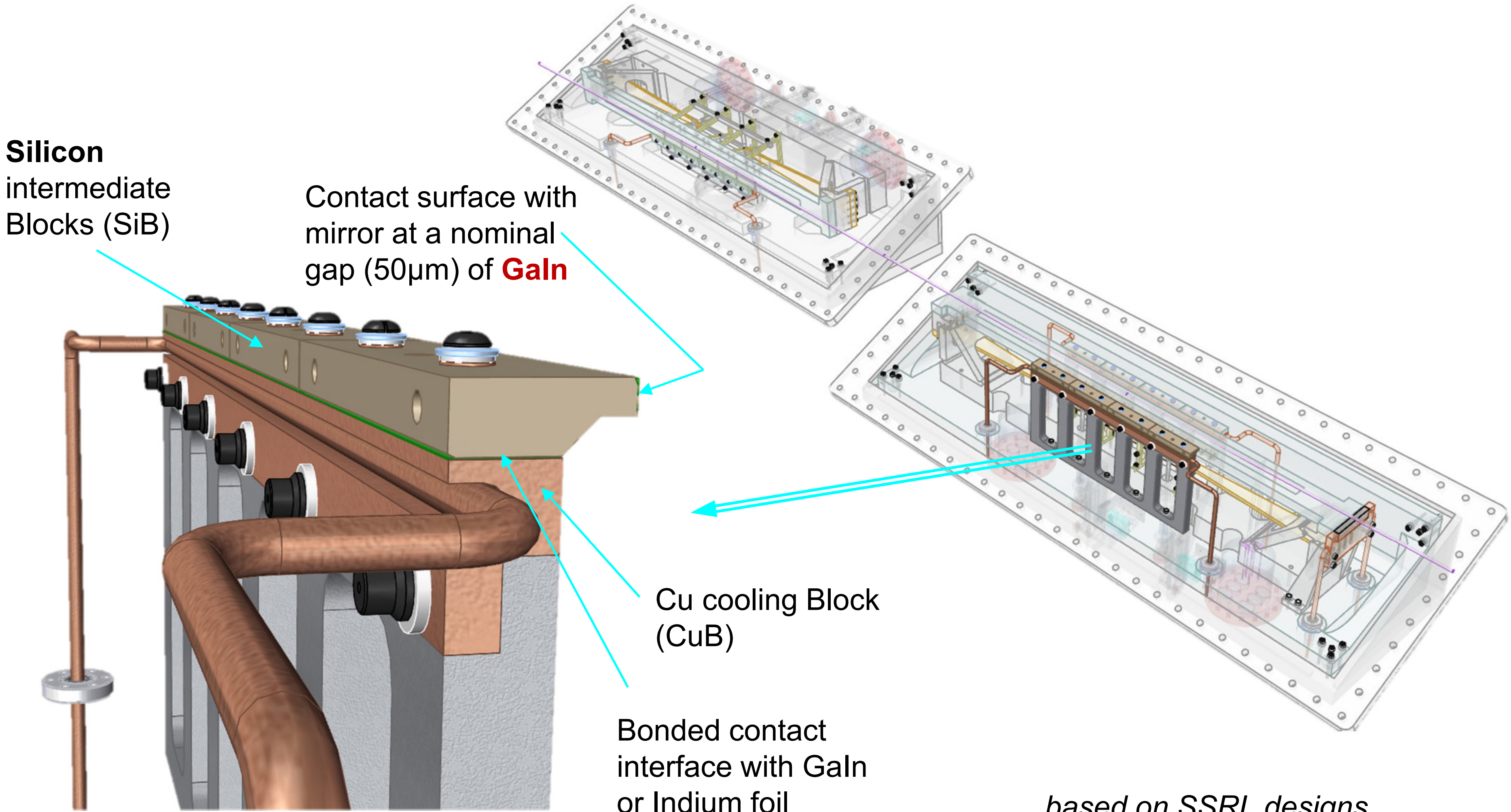
- **High Thermal Loads & Variable Footprint → Innovated Cooling**
- Minimize the coupling between the mirror Bending & Cooling

Final cooling design

- Contact (Top-up-side), one single length water cooling



based on SSRL designs for contact cooled mirror

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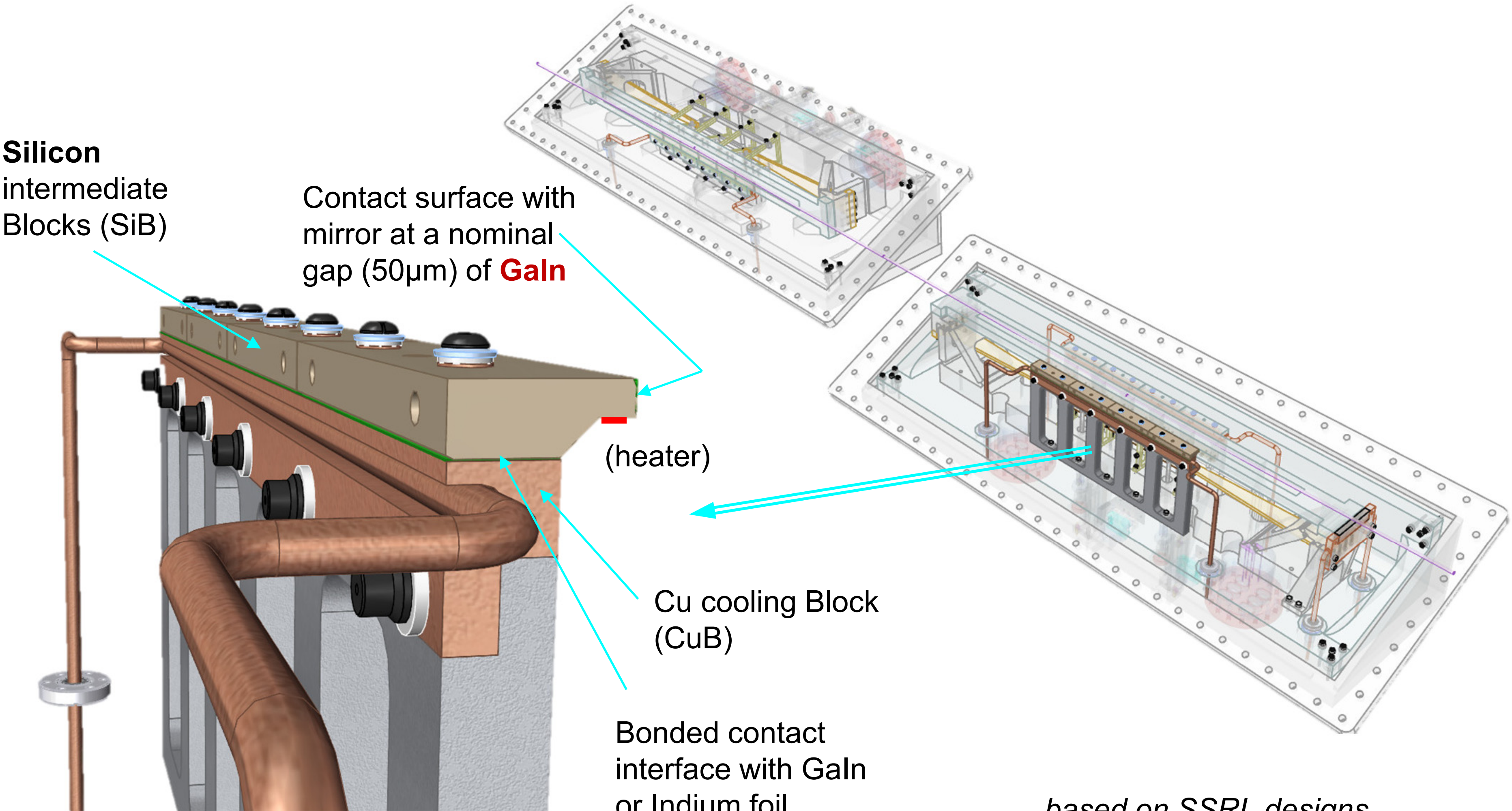


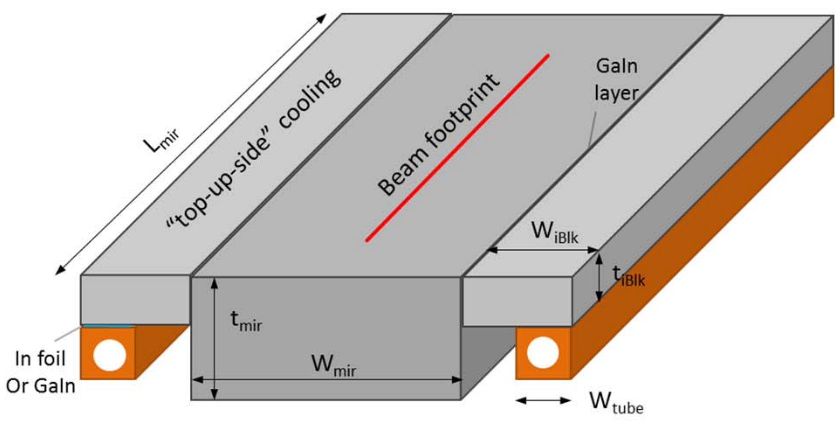
based on SSRL designs for contact cooled mirror

Mirror cooling design – 3 schemes

- *L. Zhang et al.* ***J. Syn. Rad.*** *(2015).* ***22****,1170–1181*
- *L. Zhang et al. ,* ***SRI 2015 Conference***

➢ **Top-up-side water cooling**

1. Single-length cooling



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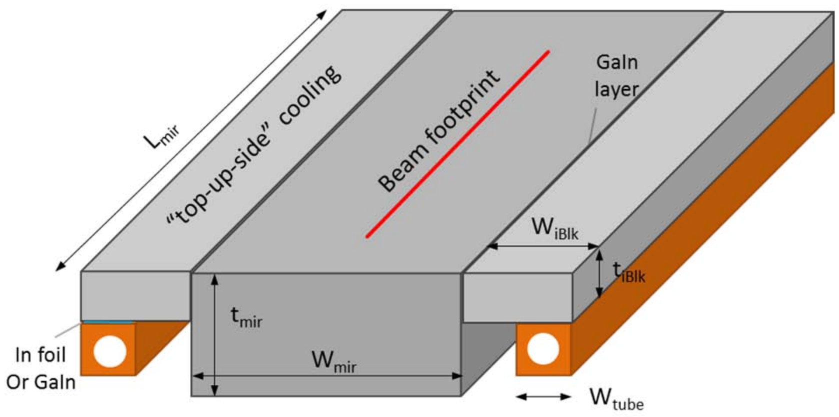
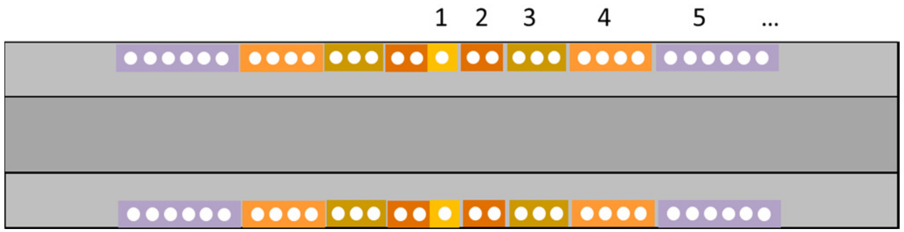


2. Variable-length cooling



back face view

Mirror cooling design – 3 schemes

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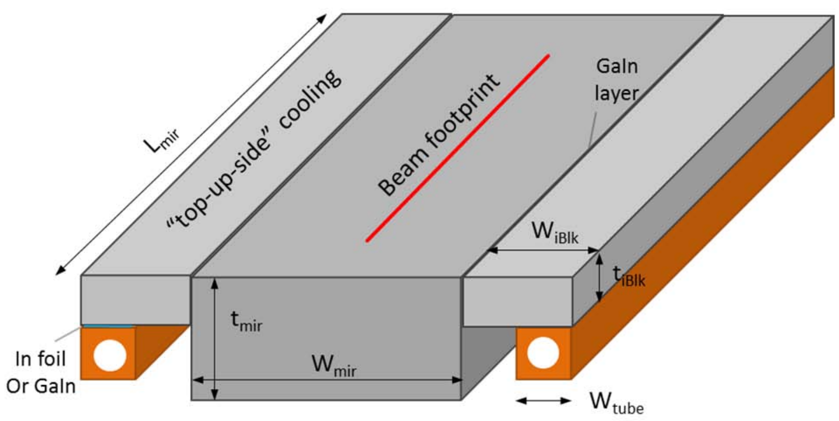
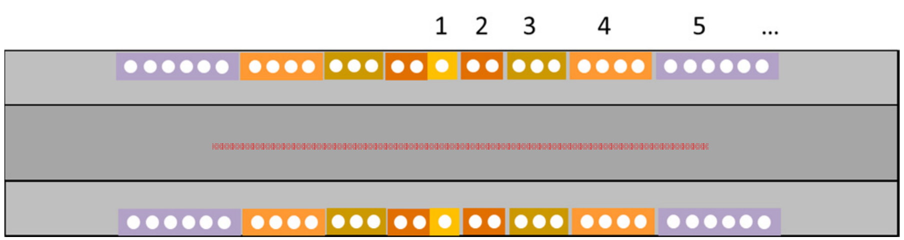
- *L. Zhang et al. ,* ***SRI 2015 Conference***

1. Single-length cooling



2. Variable-length cooling



back face view

Mirror cooling design – 3 schemes

➢ **Top-up-side water cooling**

- *L. Zhang et al.* ***J. Syn. Rad.*** *(2015).* ***22****,1170–1181*
- *L. Zhang et al. ,* ***SRI 2015 Conference***

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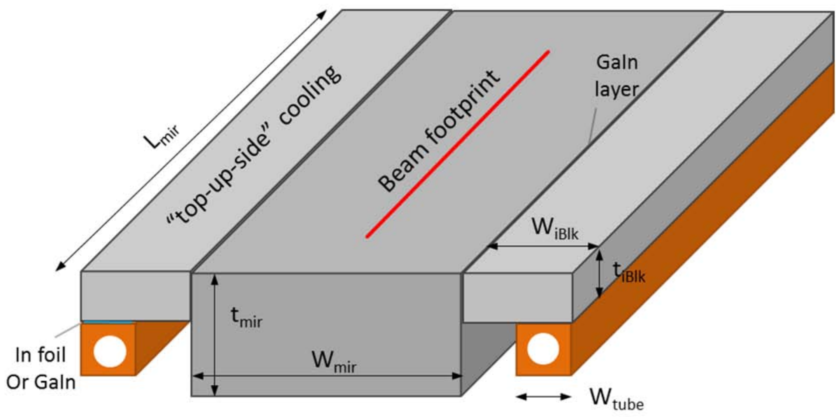

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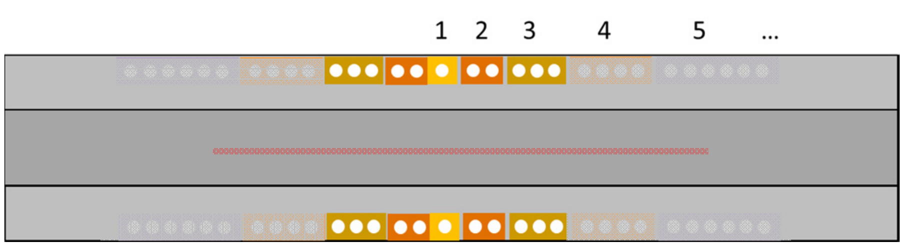

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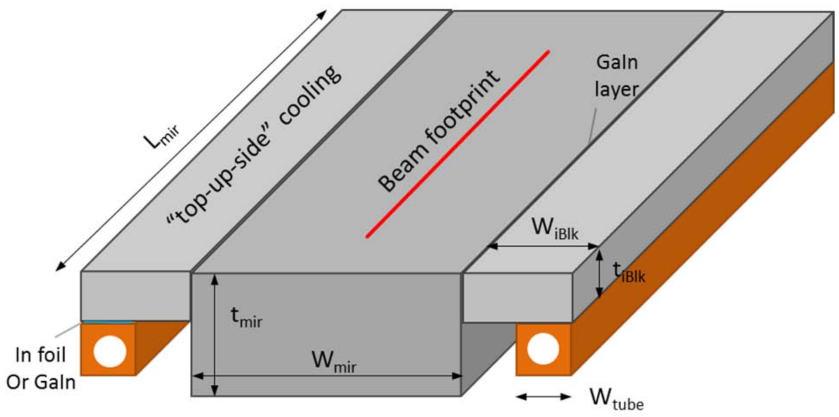

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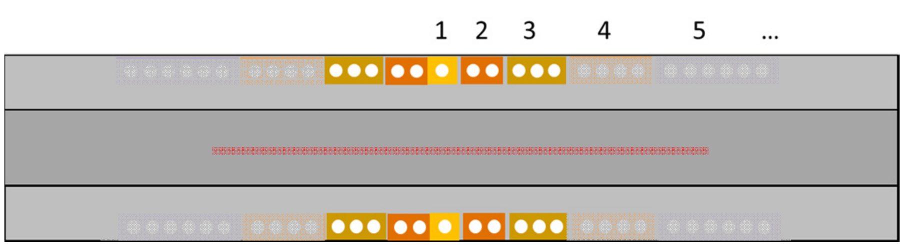
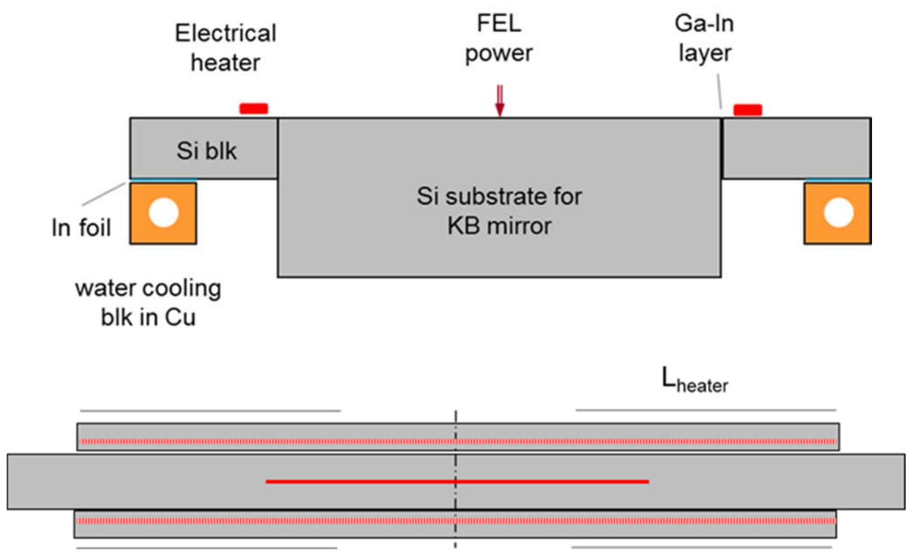


back face view

3. Electric heater + Single-length cooling



optical face view

Mirror cooling design – 3 schemes

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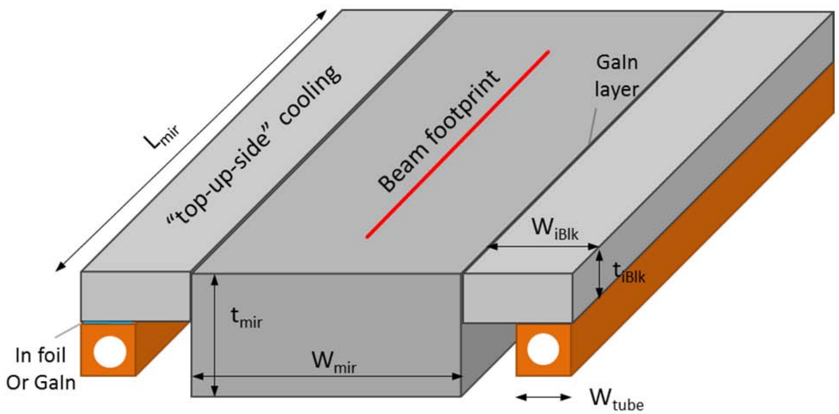

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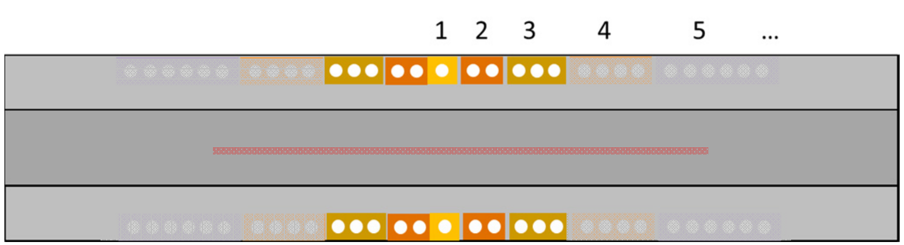

back face view

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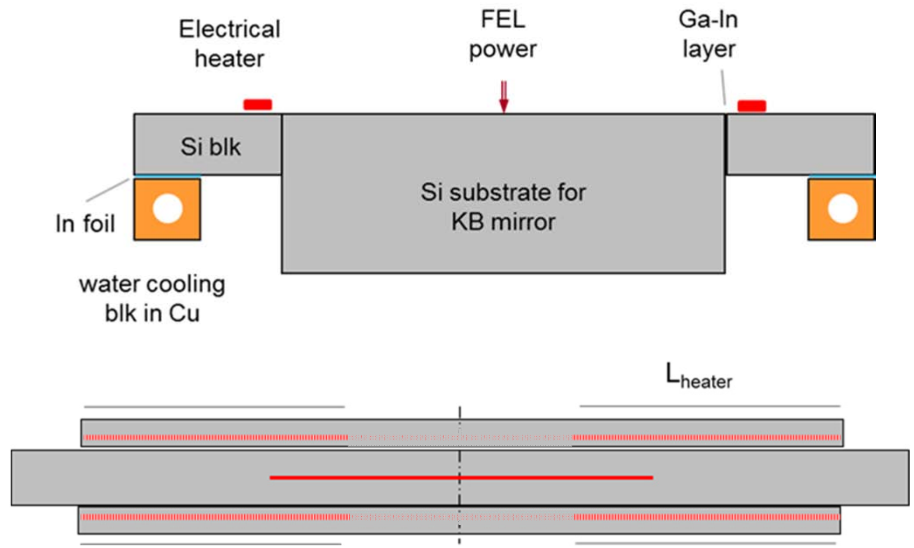

optical face view

Mirror cooling design – 3 schemes

SLAC

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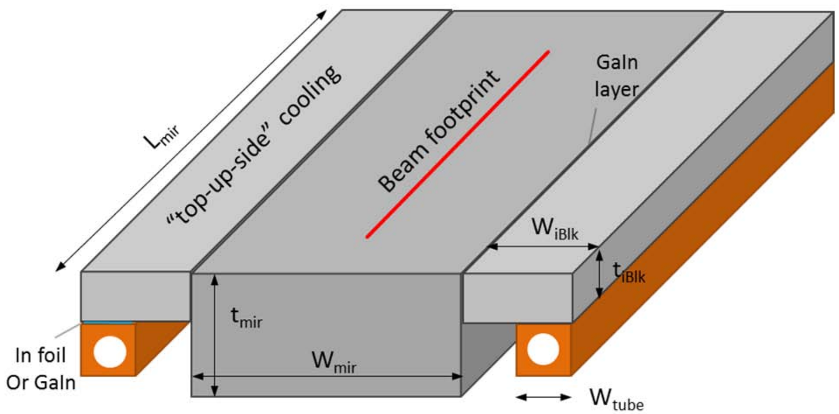

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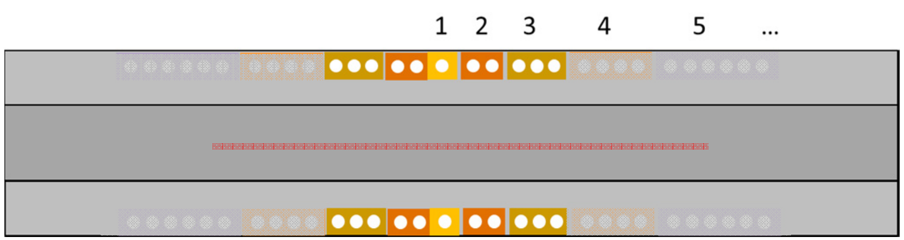
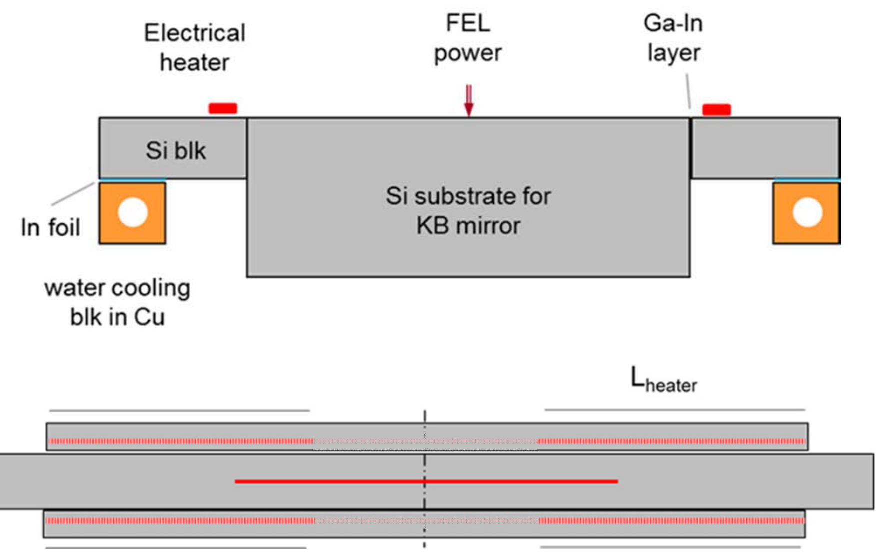


back face view

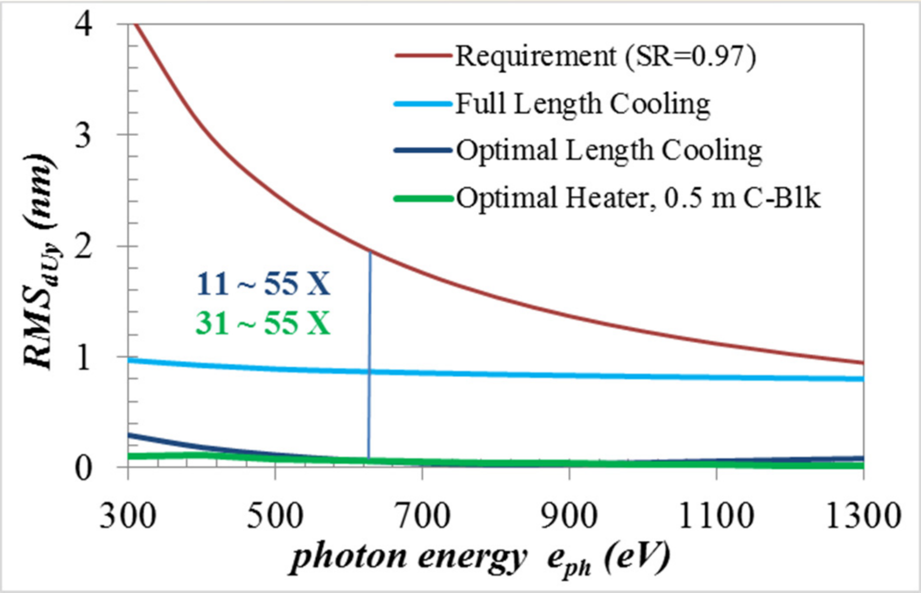
3. **Electric heater** + Single-length cooling



optical face view

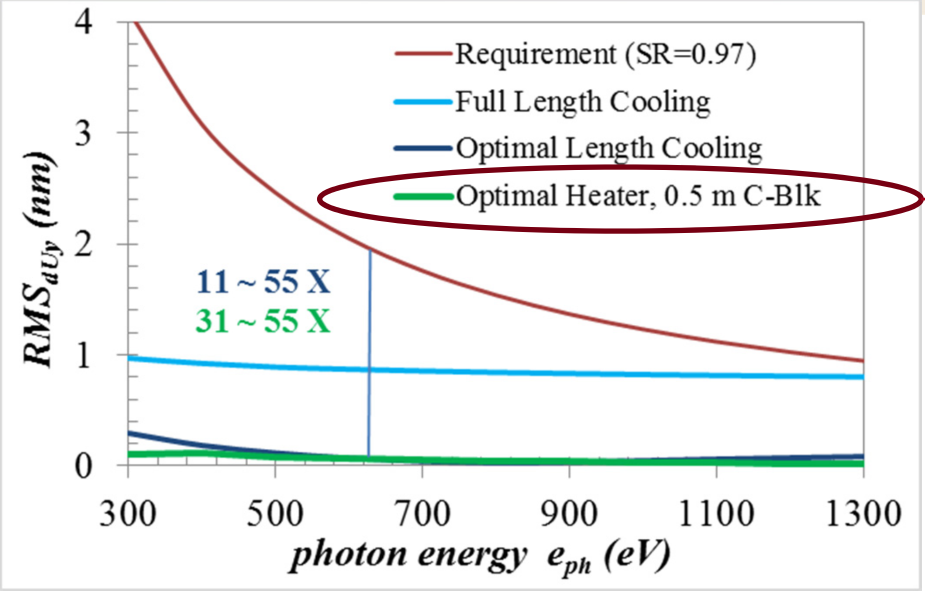
$$RMS_{thermal} := f\,(L_{heater}, Pa_{heater}, x)$$

Mirror cooling design – performance



- LCLS-II SXR K-B mirrors
  - For 20 W of XFEL beam power, full-length (top-up-side) cooling is sufficient
  - For 200 W of XFEL beam power, optimal, variable-length cooling is needed

Mirror cooling design – performance



Resistive Element Adjustable Length

REAL Cooled Optics

(DoE funded R&D project, 2017-2018 FY)

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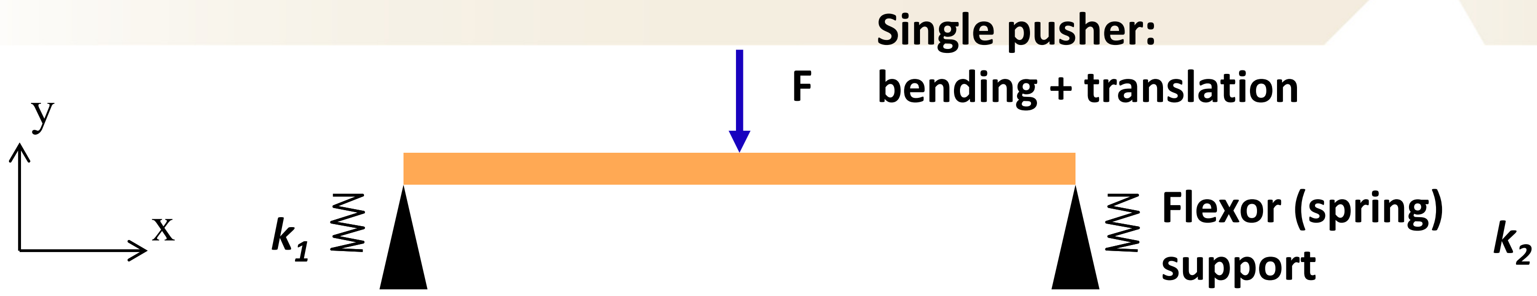
  - For 200 W of XFEL beam power, optimal, variable-length cooling is needed

Technical challenges

- Large Acceptance → Long mirror
- Variable Source & Focal Points → Bendable Mirror
- Sub Nanometer Shape Error → Limited Suppliers
- High Demagnification → Tight Bending (stress issues,…)
- Sub-μrad residual bending error → Variable Mirror Width
- High Thermal Loads & Variable Footprint → Innovated Cooling

- Minimize the **coupling between the mirror Bending & Cooling**
  - Minimization of mechanical constraint effects of Eutectic GaIn as thermal interface *(presented WEBA02)*
  - **Bend cooling blocks (design optimization practice)**

Cooling blocks bending and translation



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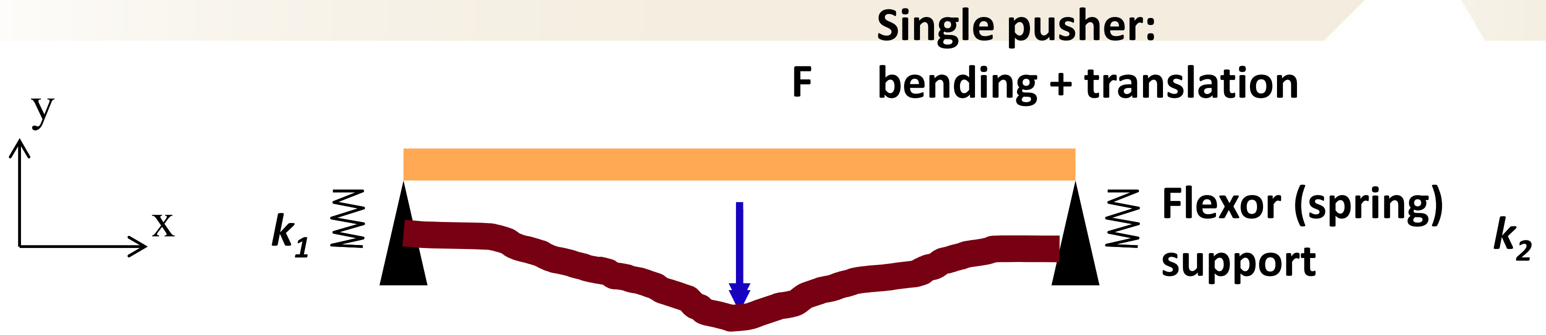

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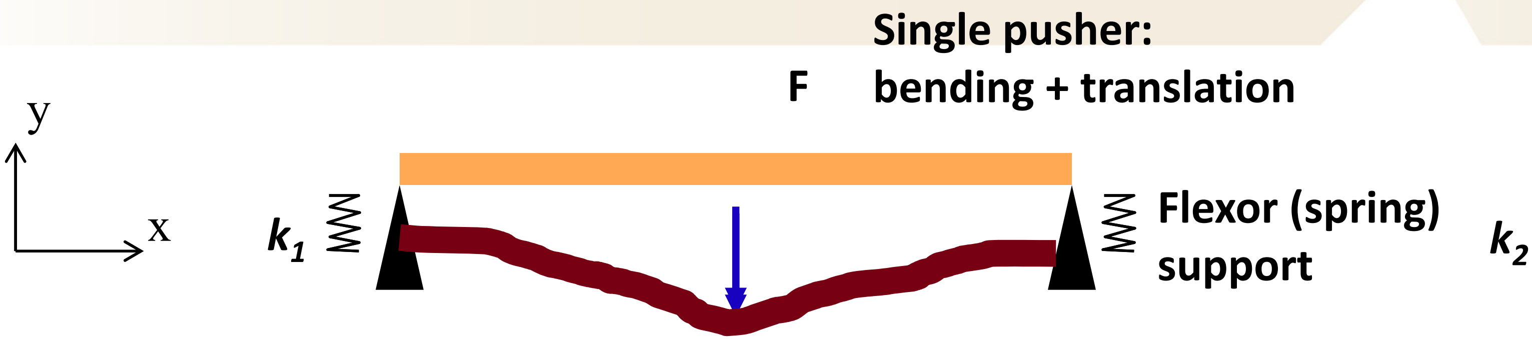


- Cooling block bent shape: $\mathbf{y_{CB}(x, \mathit{F}, \mathit{k_1}, \mathit{k_2})}$
- Mirror shape (ideal ellipse): $\mathbf{y_{mir}(x, q)}$

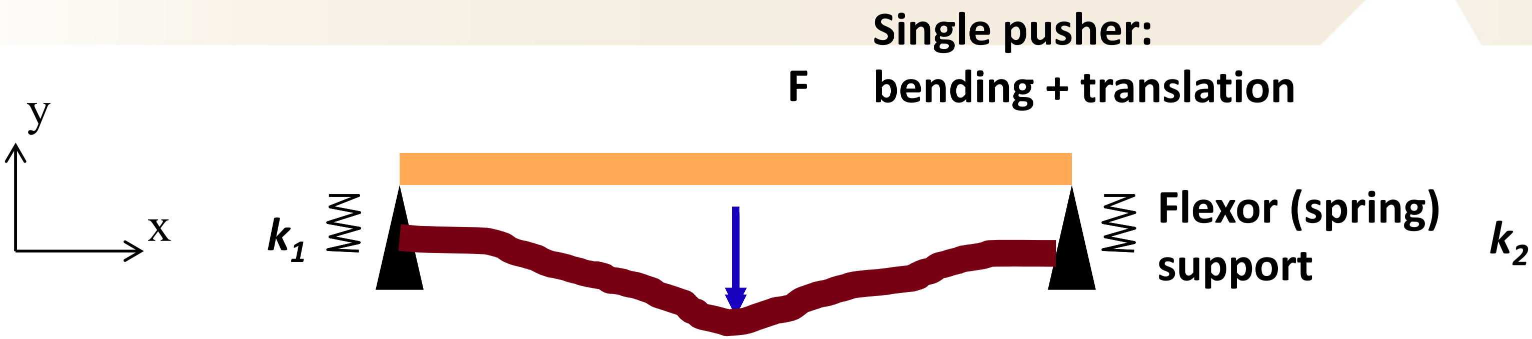
$$z(x) = \frac{\sin\theta(p+q)}{4pq+(p-q)^2\cos^2\theta} \times \{2pq - 2[(pq)^2 - pqx^2 - xpq(p-q)\cos\theta]^{1/2} - x\cos\theta(p-q)\}$$

- For given value of $\mathbf{\mathit{F}, \mathit{k_1}, \mathit{k_2}, q}$
  - Minimization : $dU_y(x) = y_{CB}(x) - y_{mir}(x)$
  - $dU_y(x) \rightarrow \mathit{RMS}, d_{pv}$

$d_{pv} < 5$ µm

Cooling blocks bending and translation

SLAC



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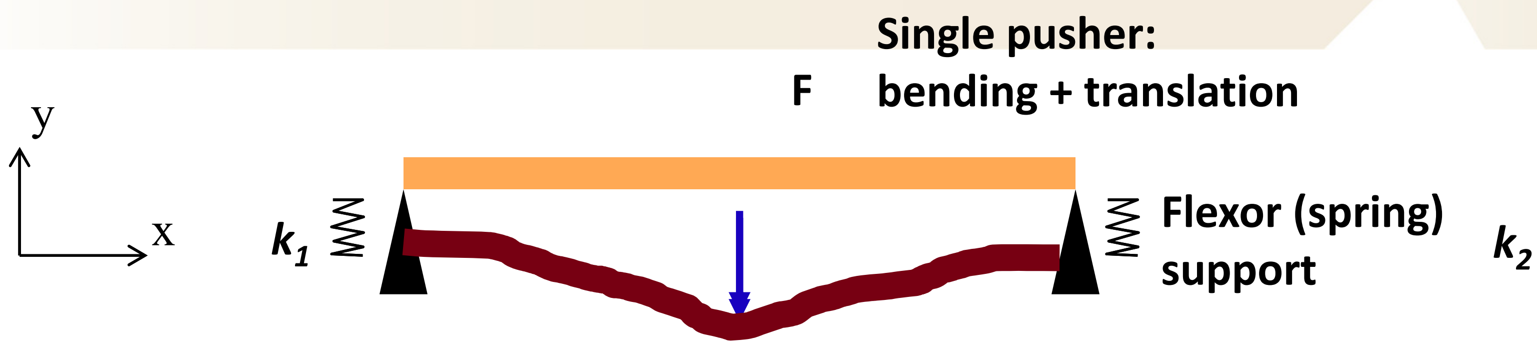
$d_{pv} < 5\ \mu m$

- **Objective function:** $f\,(F, k_1, k_2, q)$

Cooling blocks bending and translation



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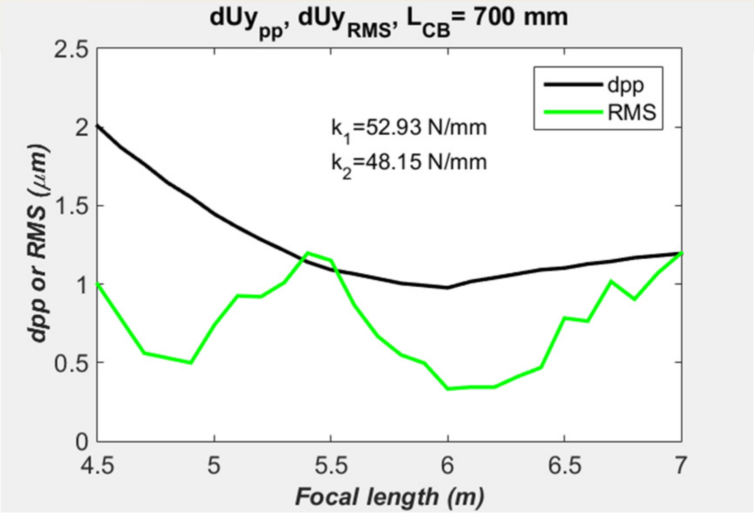
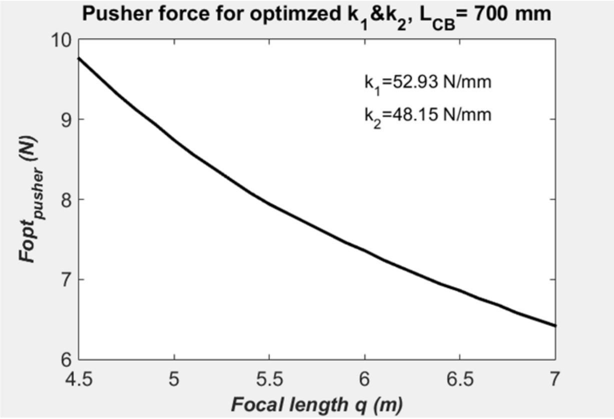
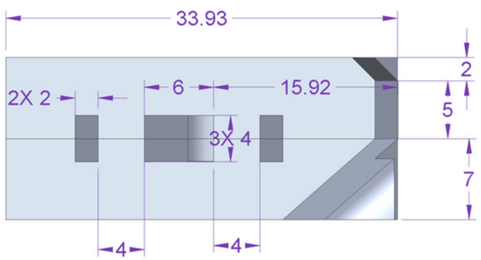
Cooling blocks: single pusher + elastic supports





- **1 pusher: F**
  2 flexor supports: k_1, k_2
  - F : 6 ~ 10 N
  - k_1 = 52.93 N/mm, k_2 = 48.15 N/mm

Uniform cross section



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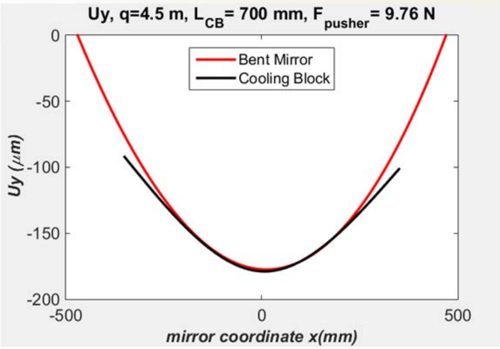

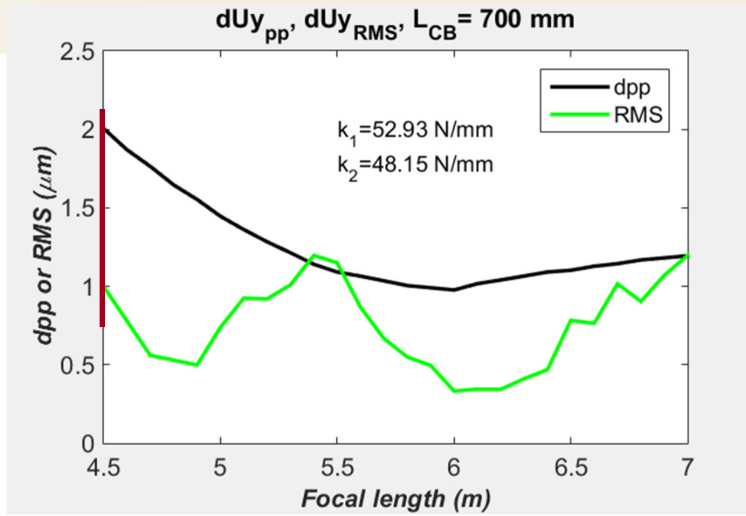

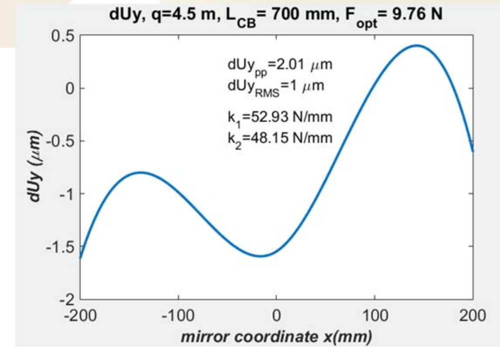

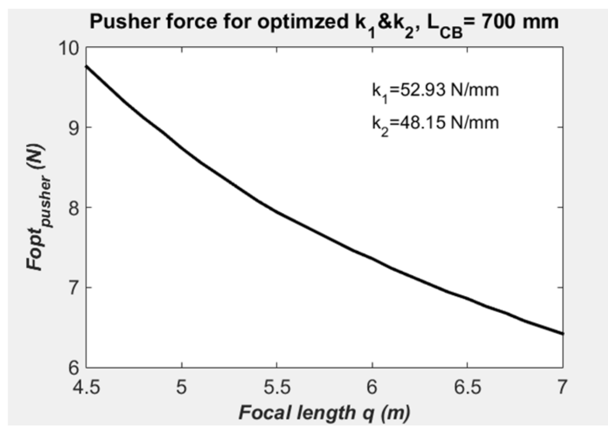

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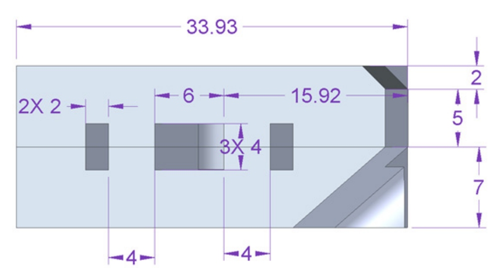

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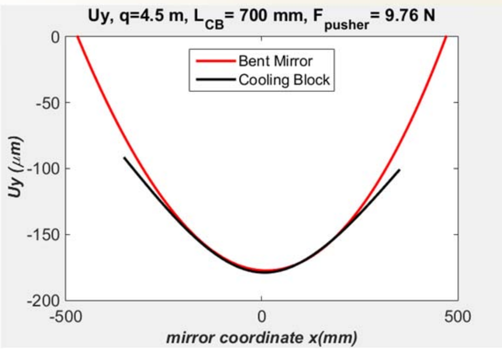

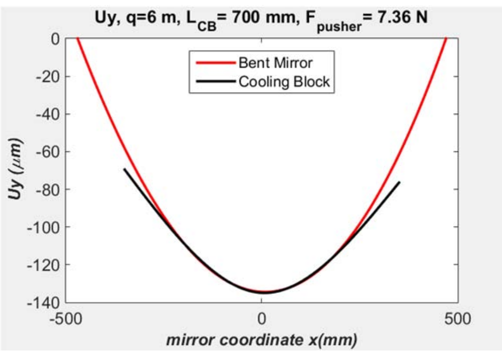

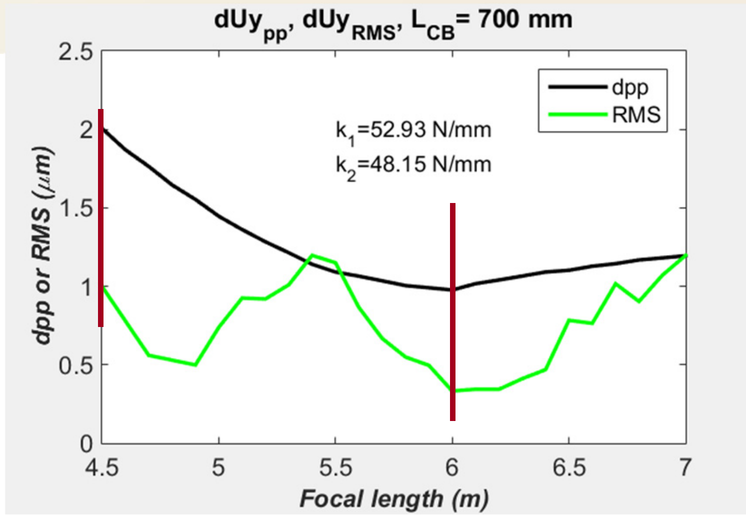

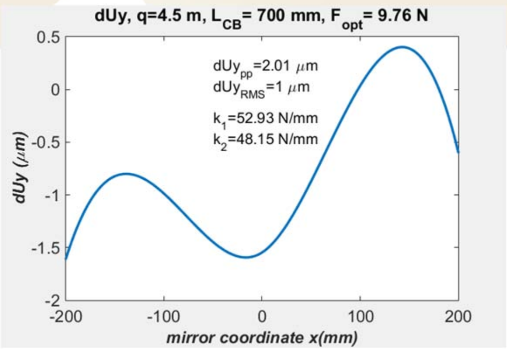

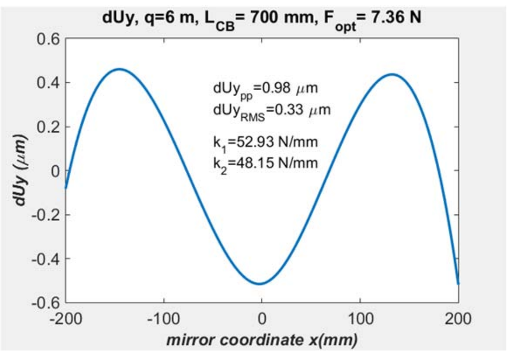

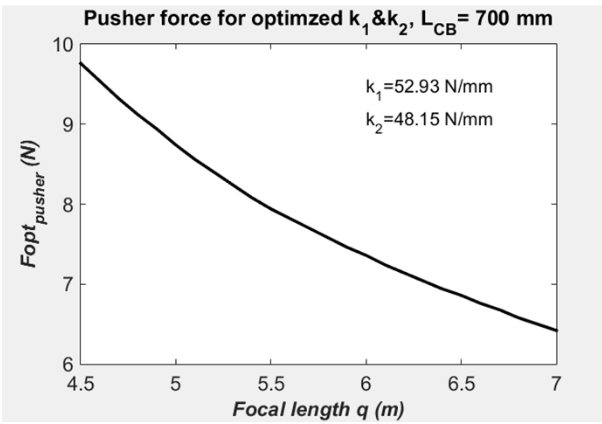

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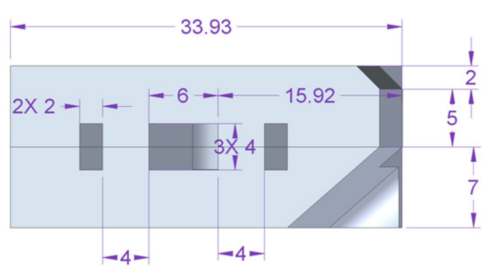


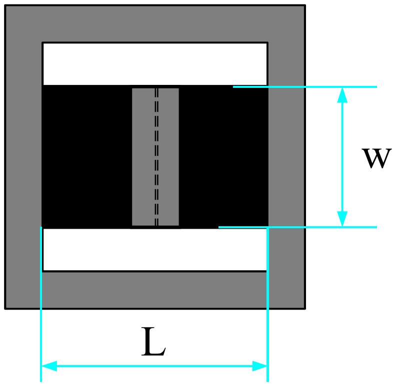
Cooling blocks: single pusher + elastic supports

➢ Flexor Supports

- Stainless steel thin blade

$$k = \frac{192EI}{L^3} = 16Ew\left(\frac{t}{L}\right)^3$$

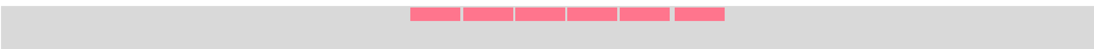
k_N (N/mm)	k_1	k_2	$\Delta_{\%}$	Δ_0	Δ_{req}
target	52.93	48.15			
			1%	*mm*	*mm*
E (N/mm^2)	2.00E+05	2.00E+05			
t (mm)	0.2	0.2	0.3%	**0.0006**	±0.01
L (mm)	20	20	0.3%	0.06	±0.05
w (mm)	16.54	15.05	1%	0.150	±0.1



- Width w (add 10% to initial values) can be adjusted (re-machined) to fit exact k-values

→ 1% accuracy for the values of k_1, k_2 should be achievable

Cooling blocks: translation + rotation



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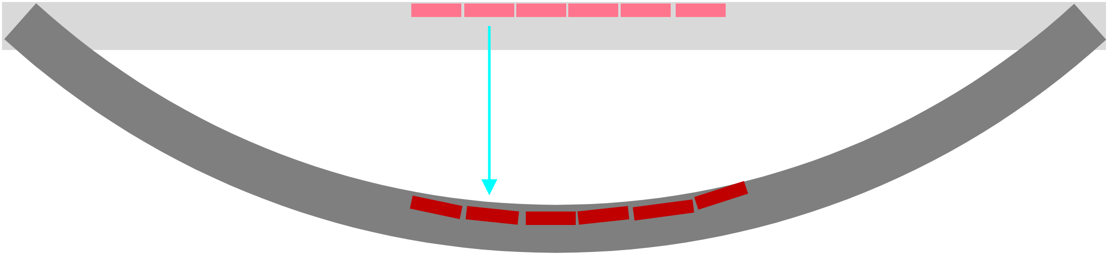

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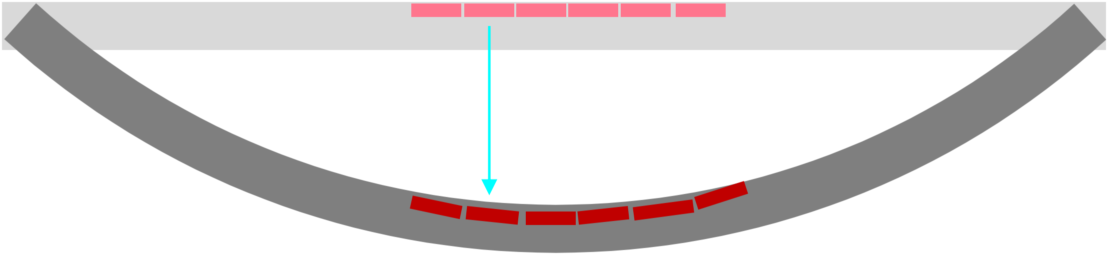

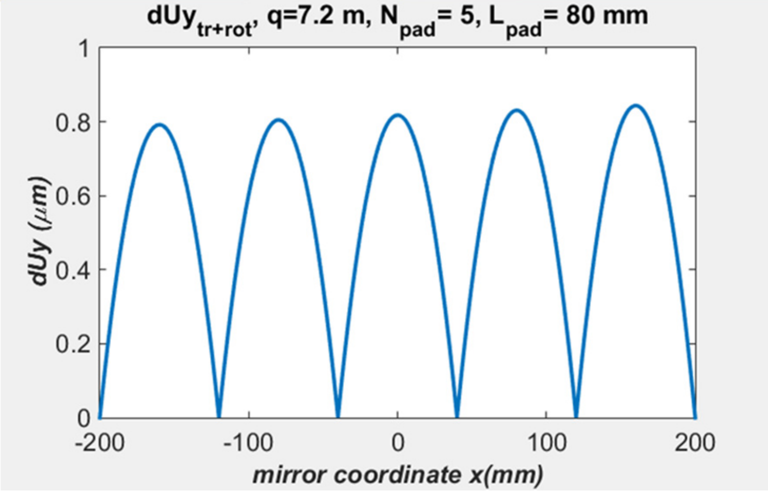

$$dU_y(x) = y_{CB}(x) - y_{mir}(x)$$

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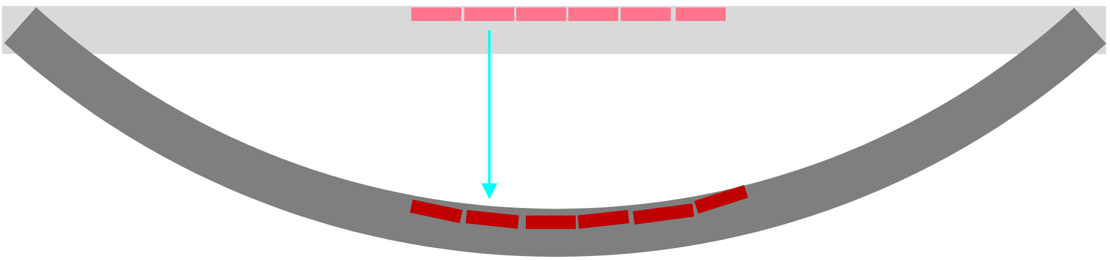

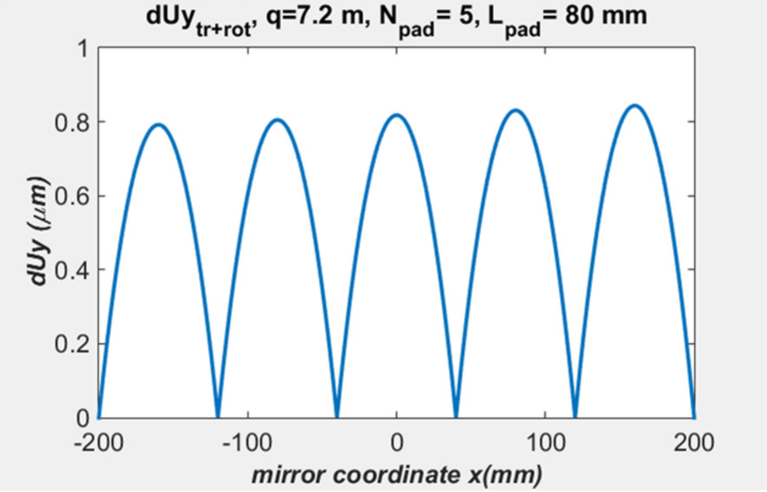

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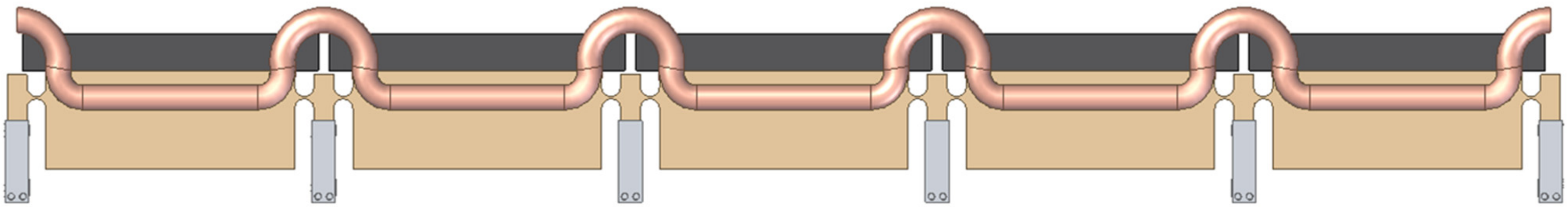
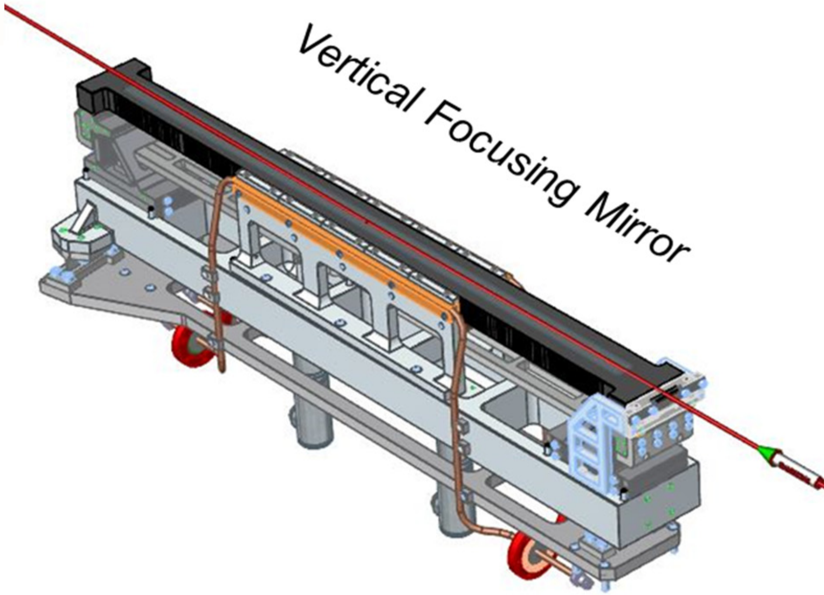
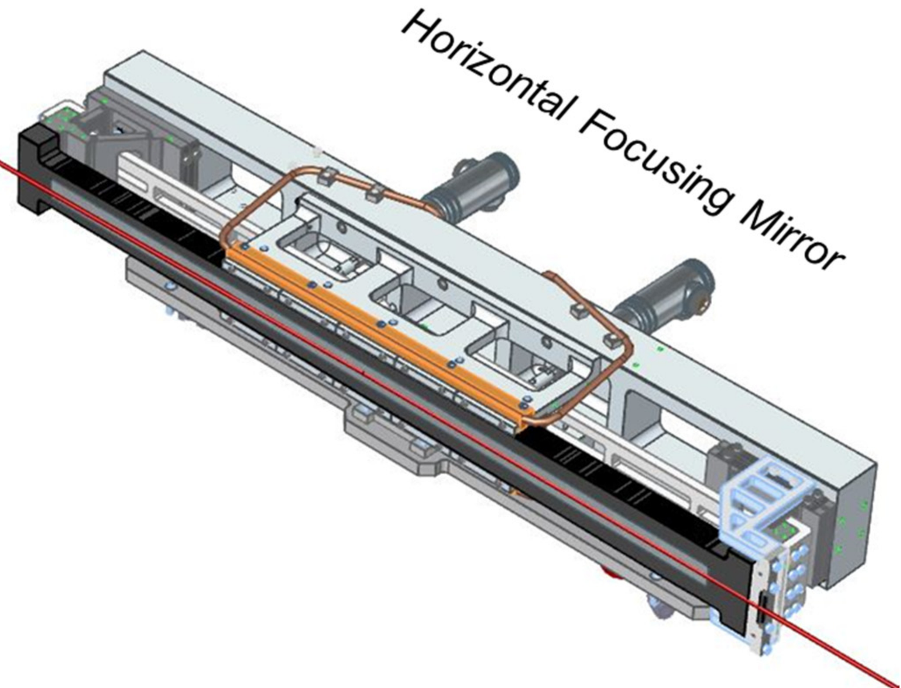


Summary



- **LCLS-II K-B mirror system**
  - Dynamically bendable
  - Water cooled



- **Prototype testing**
  - 2016 Q4
- **Final KB mirror system**
  - Mirror procurement 2017 Q1
  - Mechanics procurement 2017 Q2
  - Delivery 2018 Q1
  - Assembly, Metrology and Tests 2018 Q2
  - Installation & commission 2018 Q3

Acknowledgement

E. Anderssen	LBNL
R. Baker	ESRF
J.C. Castagna	SLAC/LCLS
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A. Ringwall	SLAC/SSRL
E. Ortiz	SLAC/LCLS-II
B. Schlotter	SLAC/LCLS-II
V. Srinivasan	SLAC/LCLS, now India
P. Stefan	SLAC/LCLS
Randy Whitney	SLAC/LCLS

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